

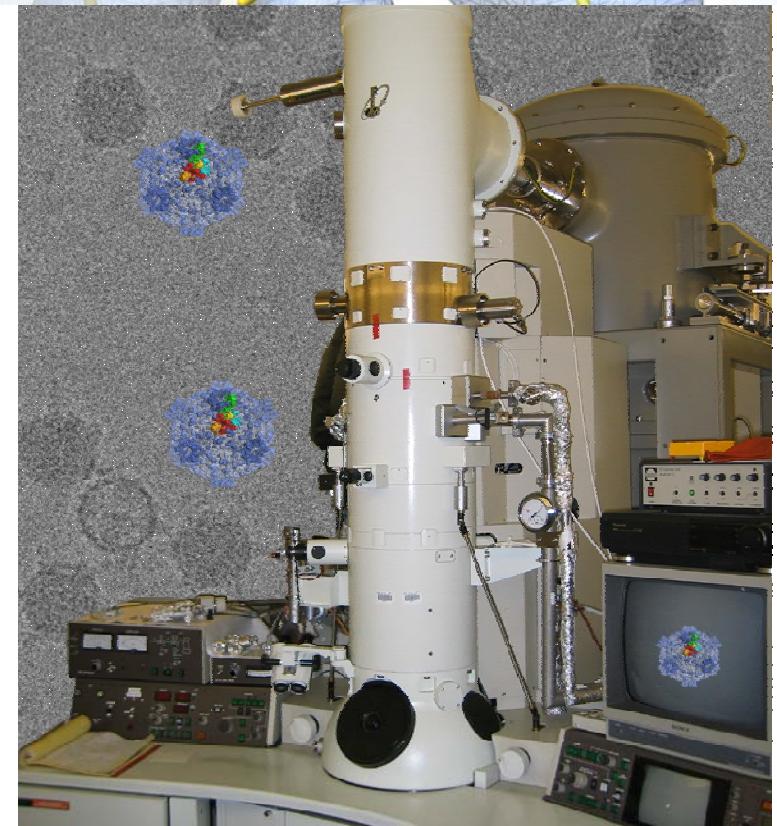
NCMI

National Center for
Macromolecular Imaging

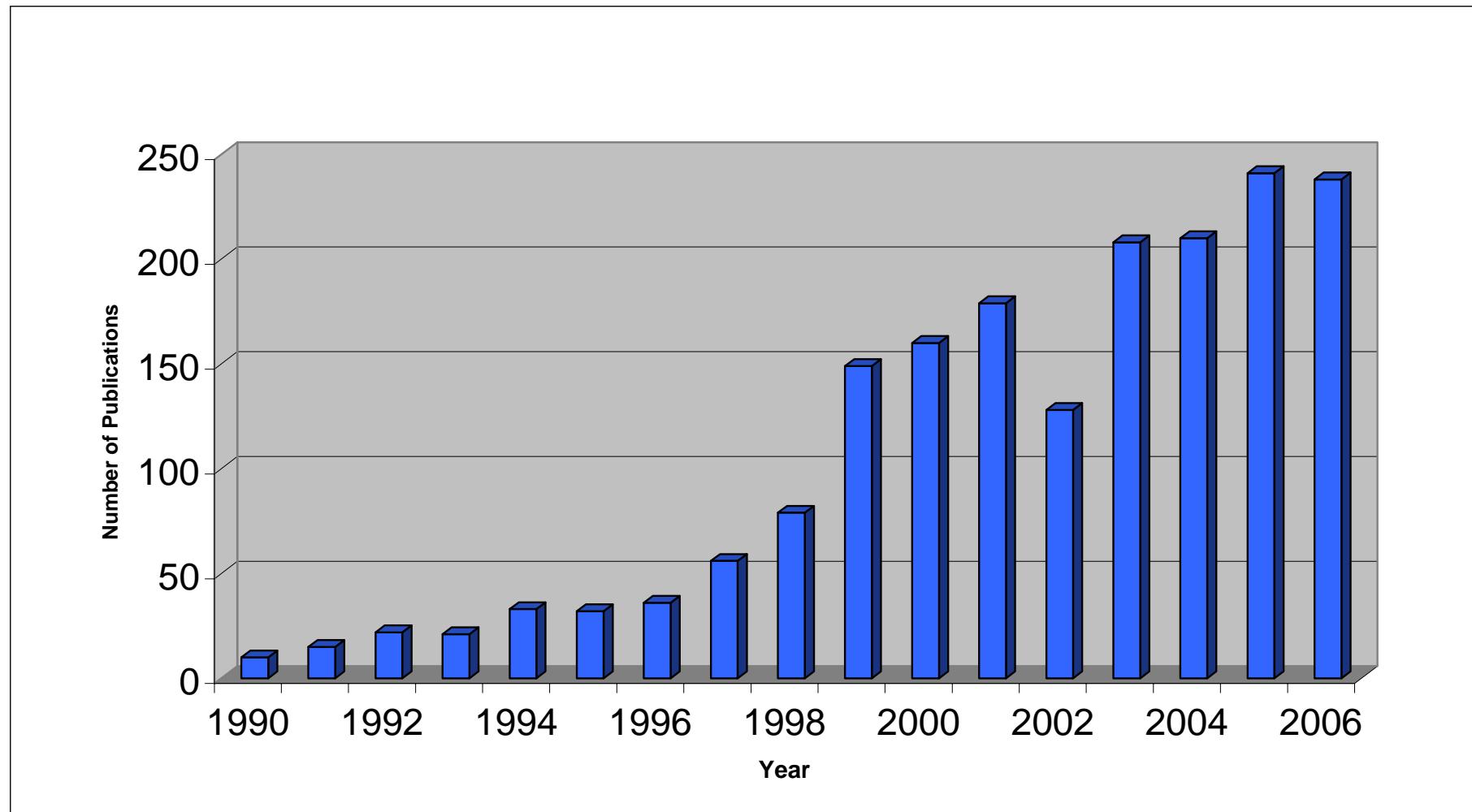
Wah Chiu

wah@bcm.edu

Baylor College of Medicine



Trends in Macromolecular Cryo-EM



Matthew Baker (2007)

From Sample to Structure

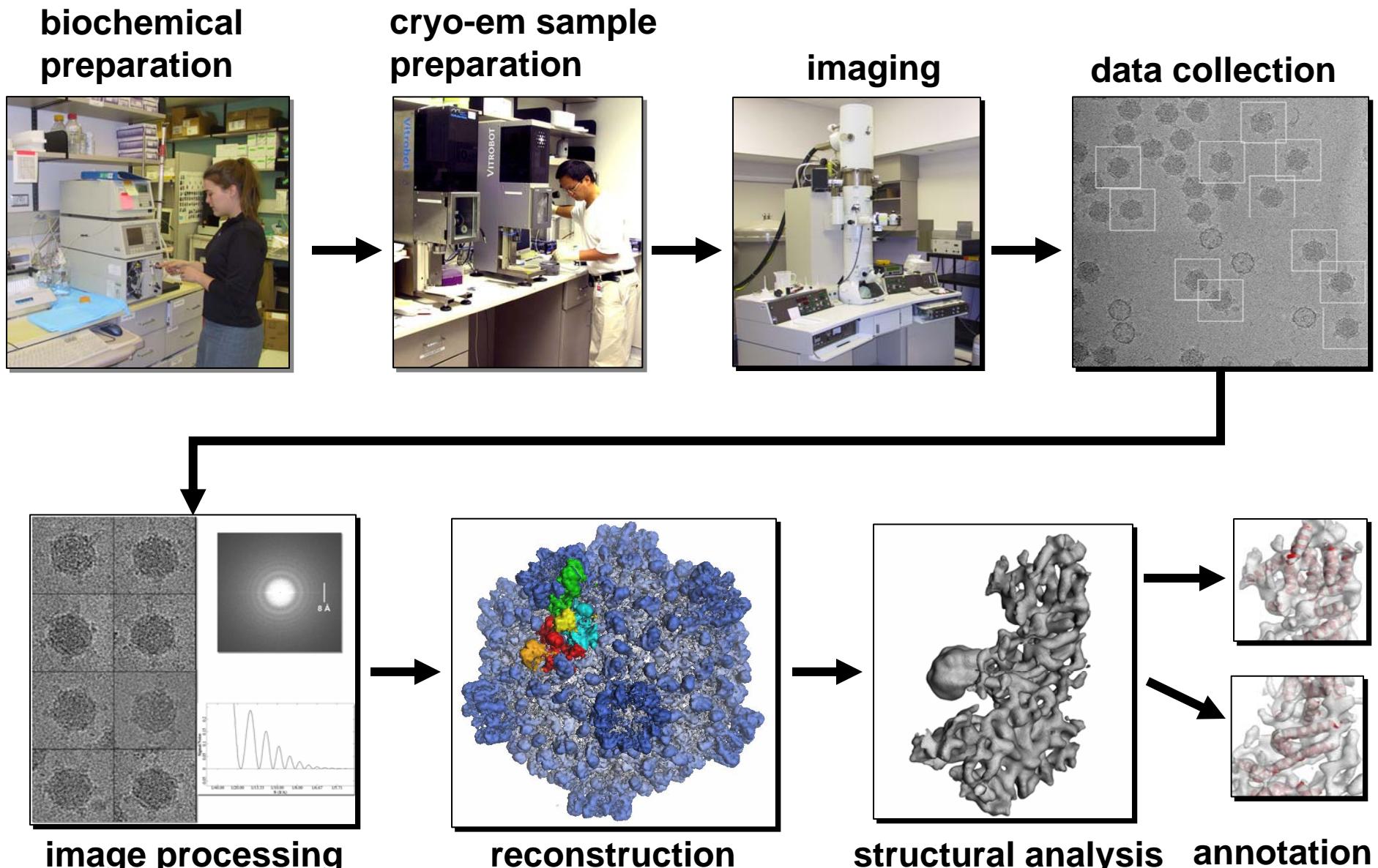


image processing

reconstruction

structural analysis

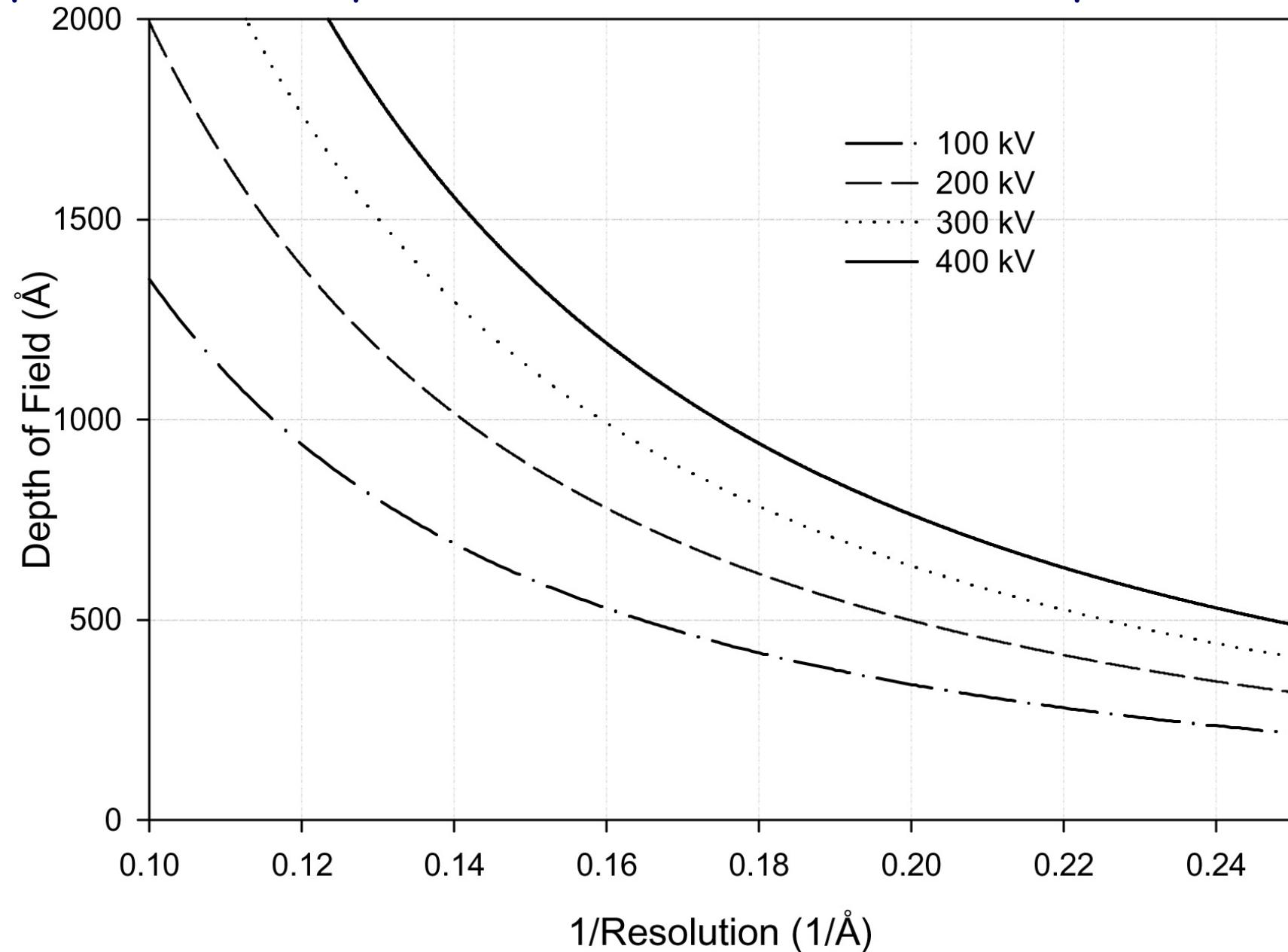
annotation

Chiu et al *JEOL News* (2006)

Image Contrast Theory

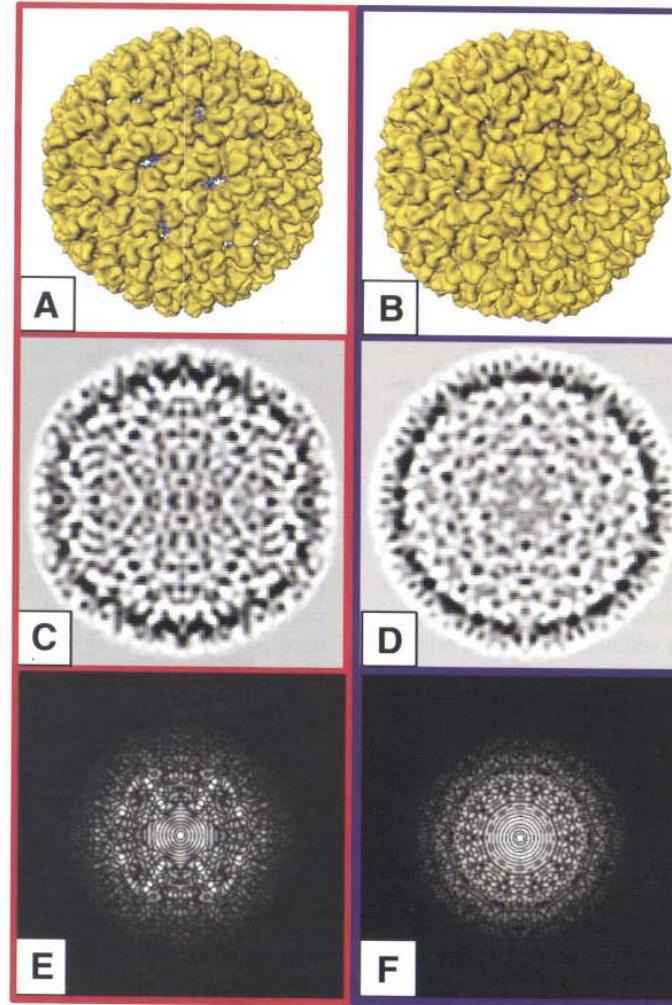
- Image is a true 2-D projection of the 3-D object with the same focus throughout
- There is only elastically scattered electron in forming the image

Depth of Field Dependence on Resolution and Sample Thickness



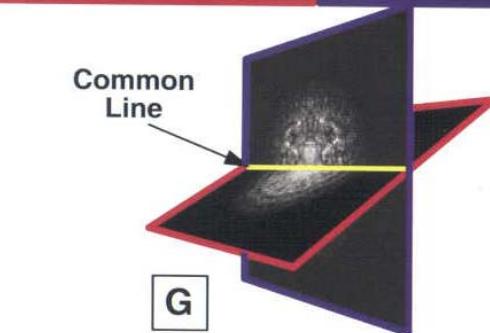
Zhou and Chiu, *Adv Prot Chem* **64**: 93-130 (2003)

3D Object



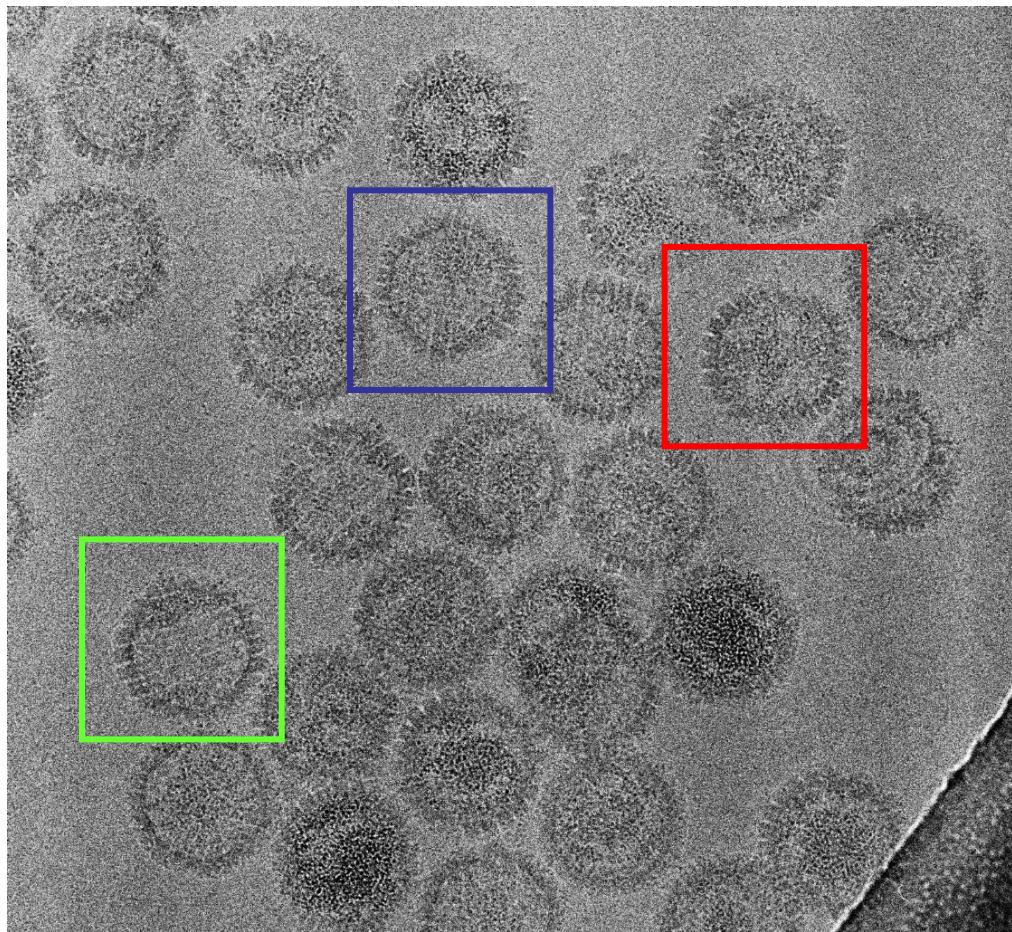
Projection Image

Fourier
Transform

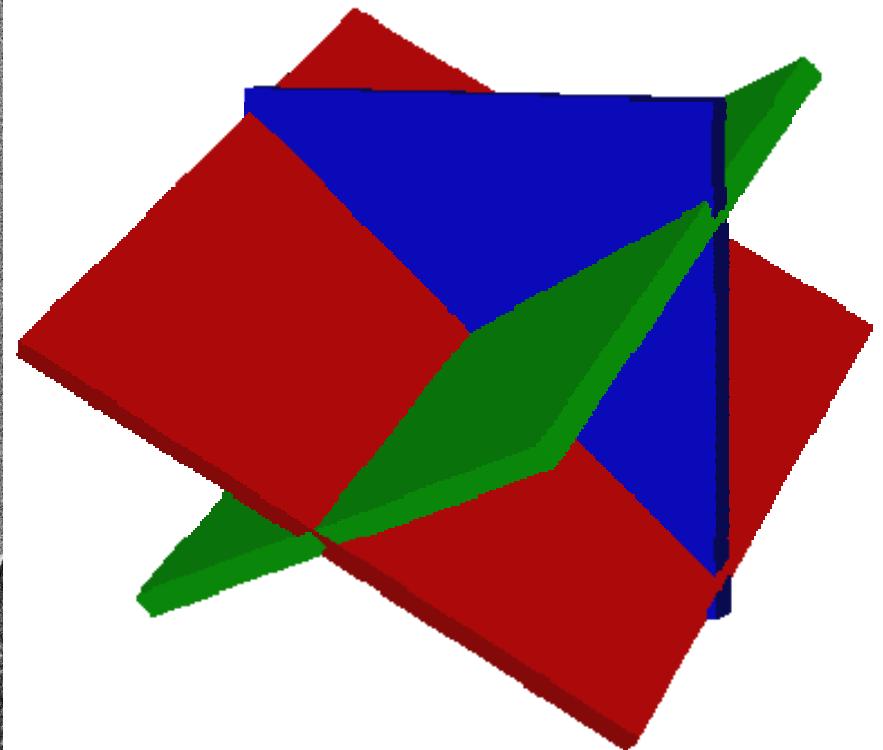


Thuman-Commike & Chiu,
Micron 31: 687-711 (2000)

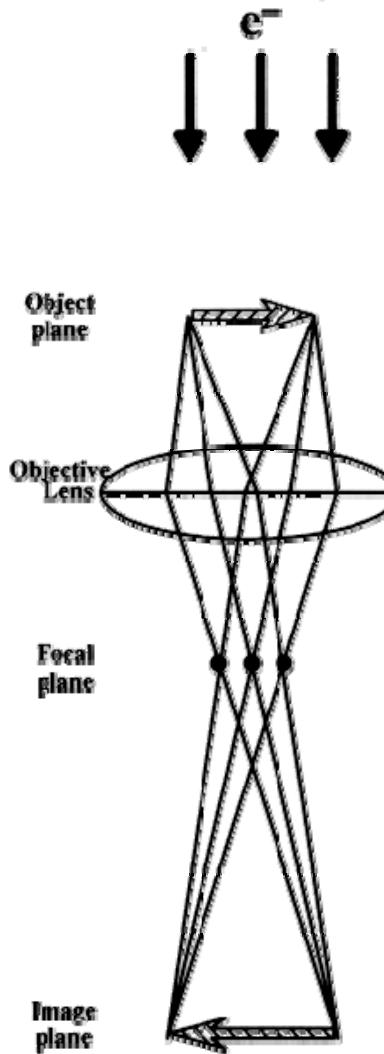
Single Particle Images



Equivalent data in
Fourier space



Hong Zhou



Object Coulomb potential function $V(x_0, y_0, z_0)$

Object transmitted wave function $\Psi_o(x_0, y_0)$

$$\Psi_o(x_0, y_0) = 1 + i\sigma(x_0, y_0)$$

$$\sigma(x_0, y_0) = \int V(x_0, y_0, z_0) dz_0$$

Phase shift $\gamma(S)$ introduced by objective lens

$$\gamma(S) = 2\pi(\frac{1}{4}C_s \lambda^3 S^4 - \frac{1}{2}A Z \lambda S^2)$$

Diffraction wave function $\Psi_d(S_x, S_y)$

$$\Psi_d(S_x, S_y) = F(S_x, S_y) \exp(i\gamma(S))$$

$$F(S_x, S_y) = \mathcal{F}[\Psi_o(x_0, y_0)]$$

$$\text{Diffraction intensity } I_d(S_x, S_y) = \Psi_d(S_x, S_y) \Psi_d^*(S_x, S_y)$$

Image wave function $\Psi_i(x_i, y_i)$

$$\Psi_i(x_i, y_i) = \mathcal{F}^{-1}[\Psi_d(S_x, S_y)]$$

Image intensity $I_i(x_i, y_i)$

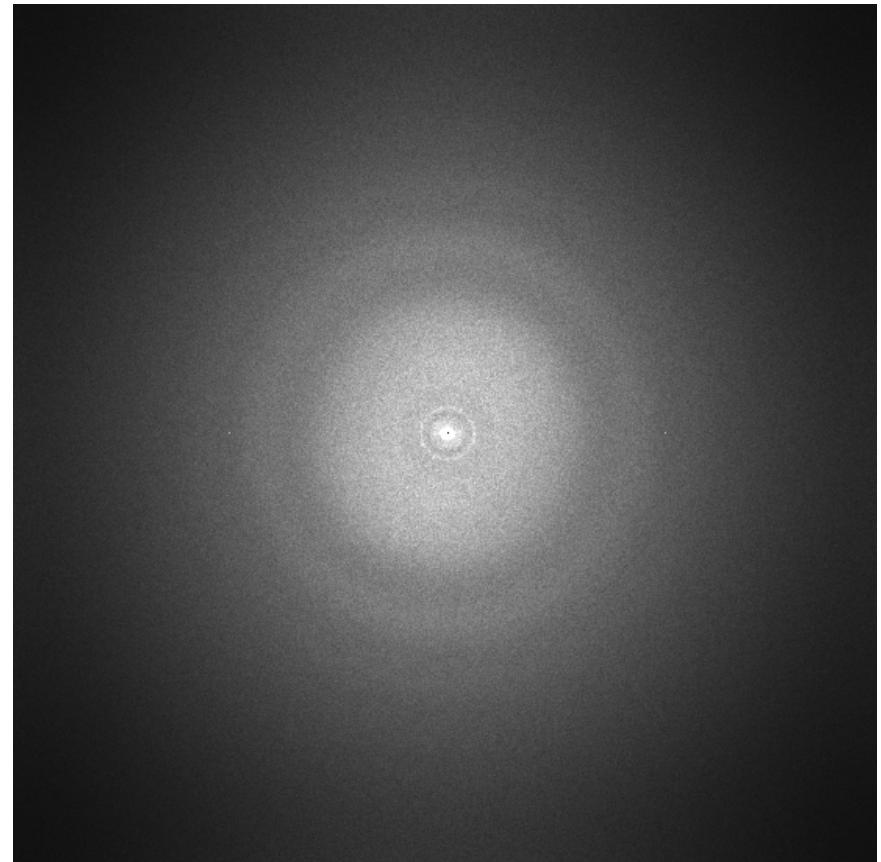
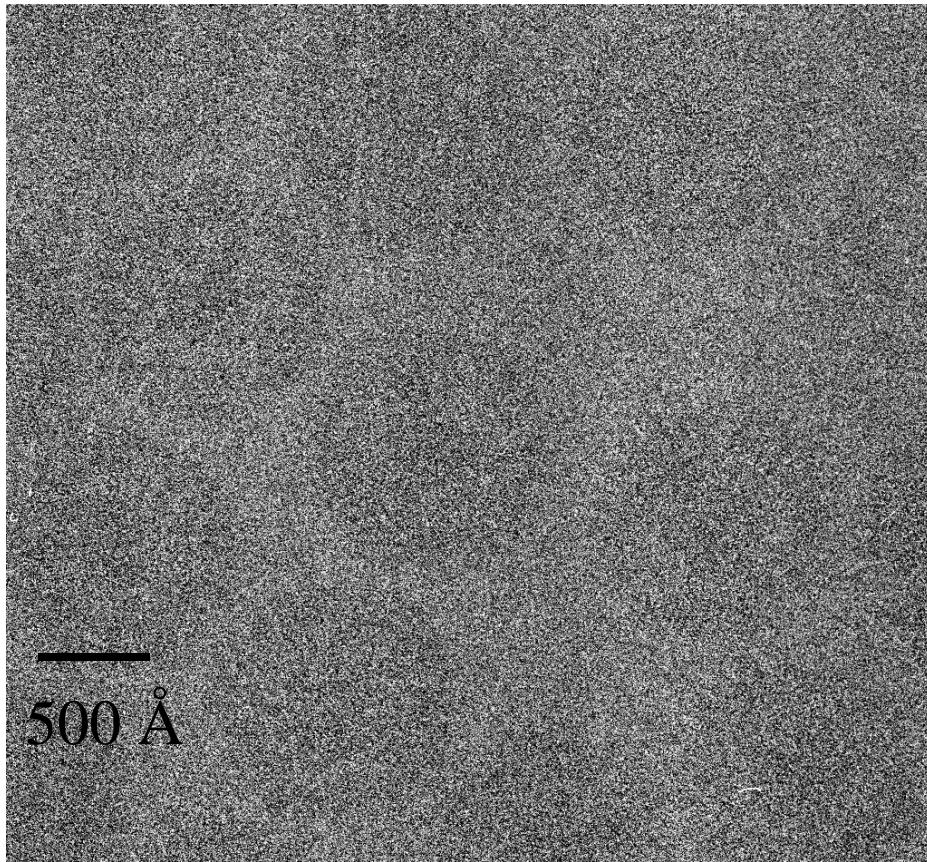
$$I_i(x_i, y_i) = \delta(0, 0) - 2\sigma(x_i, y_i) * \mathcal{F}^{-1}[\sin \gamma(S)]$$

Computed diffraction wave function $T(S_x, S_y)$

$$T(S_x, S_y) = \mathcal{F}[I_i(x_i, y_i)]$$

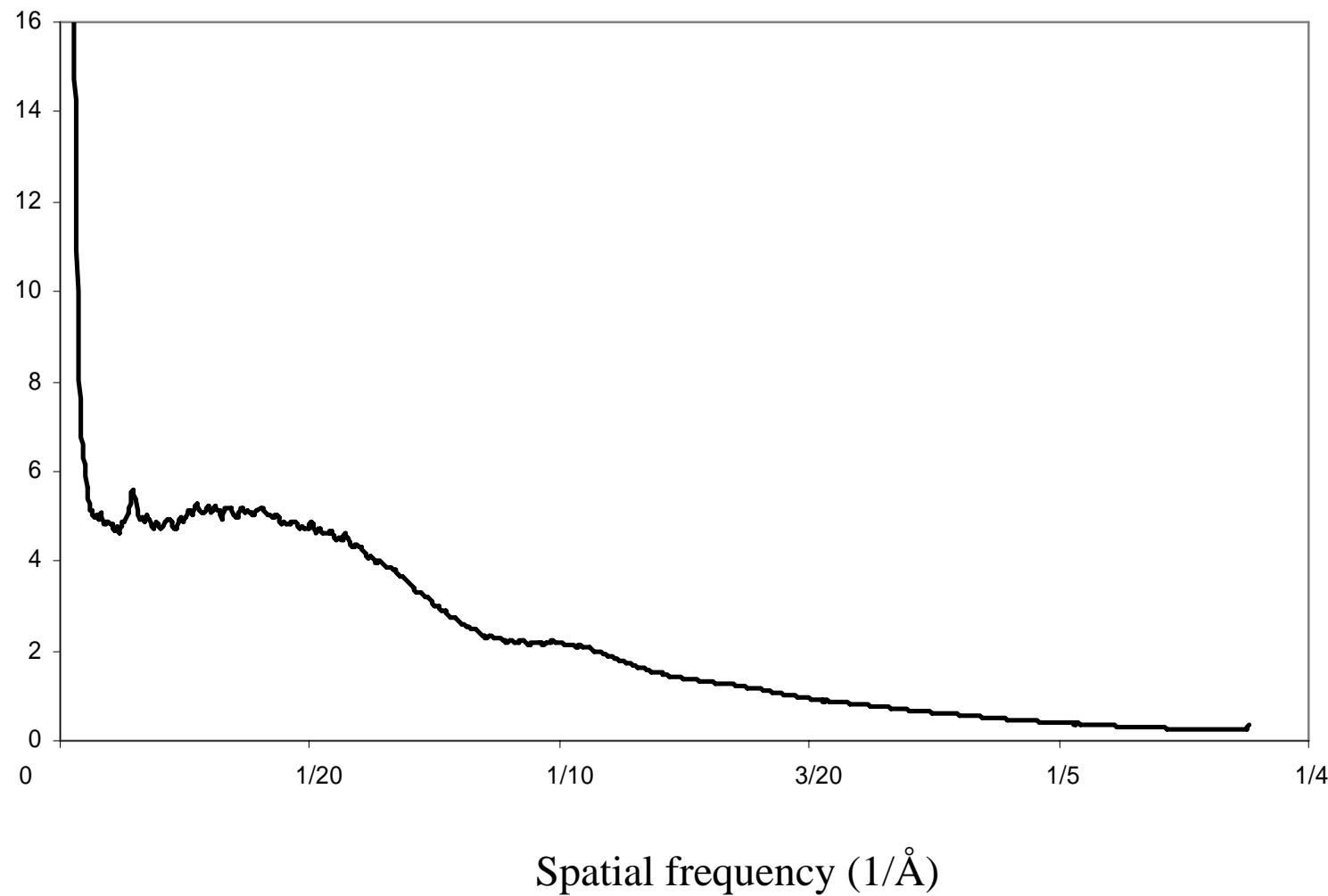
$$= \delta(0, 0) - 2 F(S_x, S_y) \sin \gamma(S)$$

400 kV image data of HSV-1 capsids



Joanita Jakana

Circularly Averaged Power Spectrum



Computed diffraction pattern

$$F^2(s) \cdot CTF^2(s) \cdot Env^2(s) + N^2(s)$$

The diagram illustrates the components of a computed diffraction pattern. It consists of four terms separated by multiplication signs. The first term, $F^2(s)$, is circled in red. Below the equation, four vertical arrows point upwards from labels to their corresponding terms: 'Structure factor' points to $F^2(s)$, 'Contrast transfer function' points to $CTF^2(s)$, 'Envelope function' points to $Env^2(s)$, and 'Background' points to $N^2(s)$.

$F^2(s) \cdot CTF^2(s) \cdot Env^2(s) + N^2(s)$

↑
↑
↑
↑

Structure factor Contrast transfer function Envelope function Background

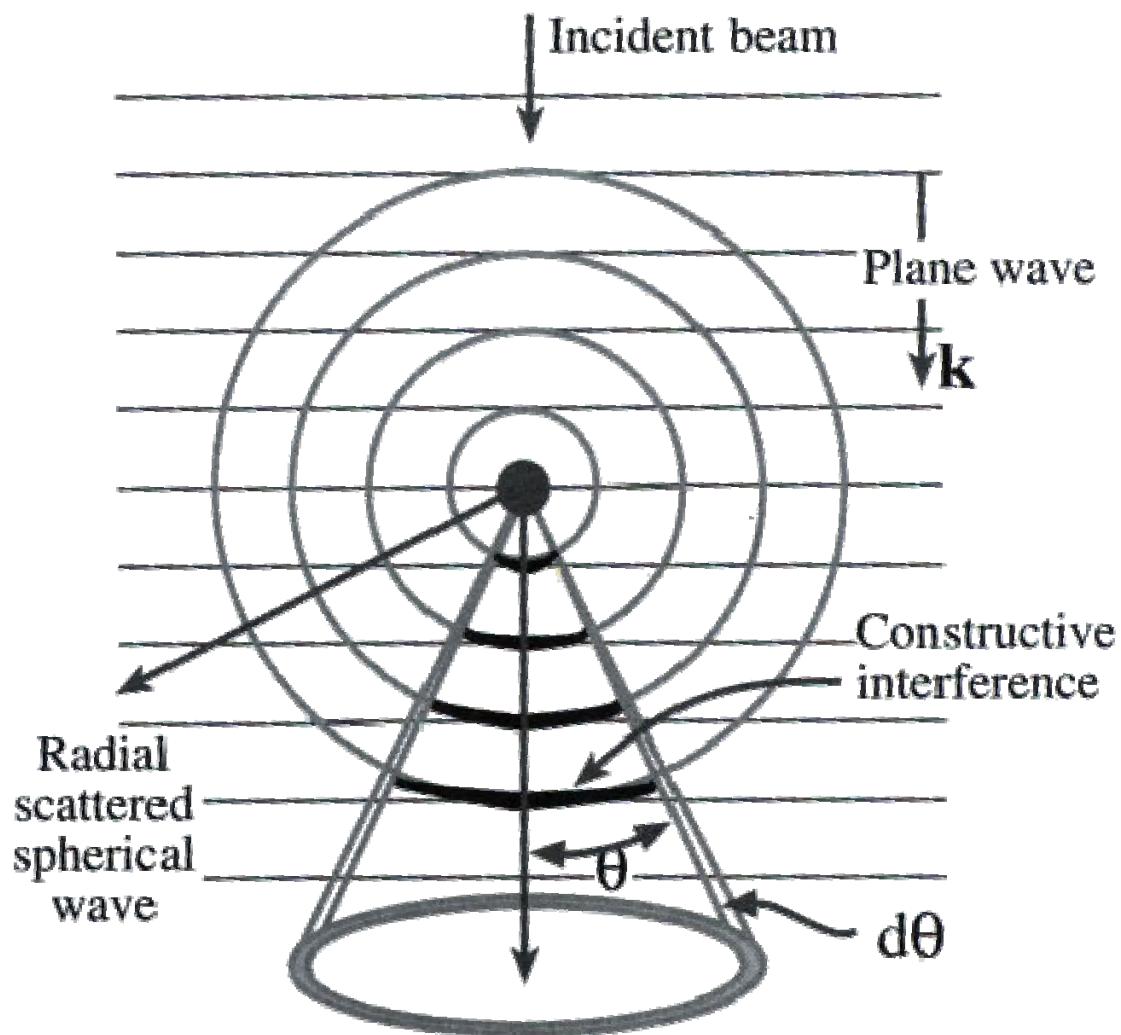


Figure 3.6. The generation of a scattered wave by the interaction of a plane wave (horizontal lines) with a point charge. The circles represent the scattered spherical wavefronts which are in phase (same λ). The in-phase constructive interference between the plane and spherical waves is shown by the dark arcs. The angles θ and $d\theta$ are the same as in Figure 2.3

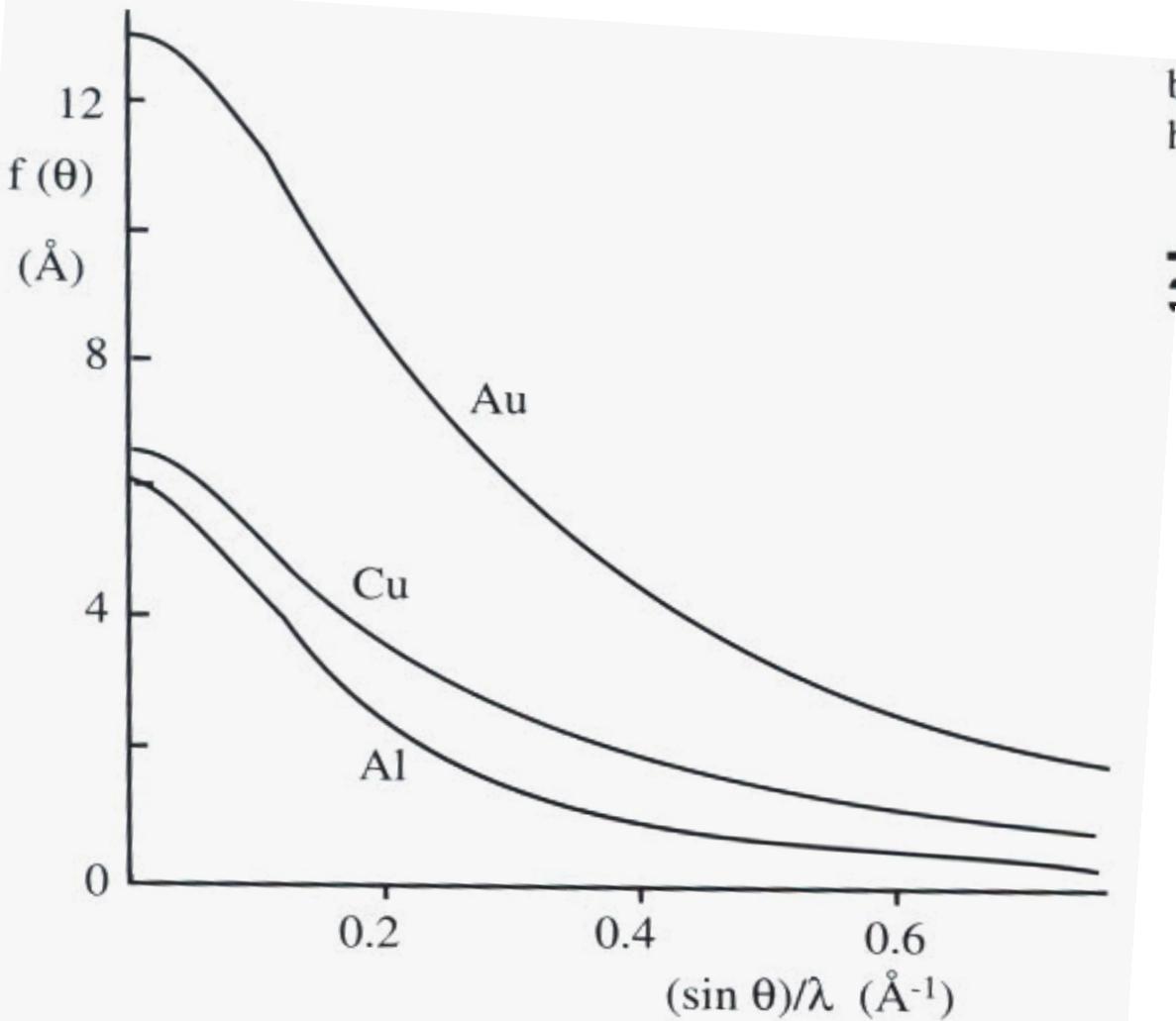
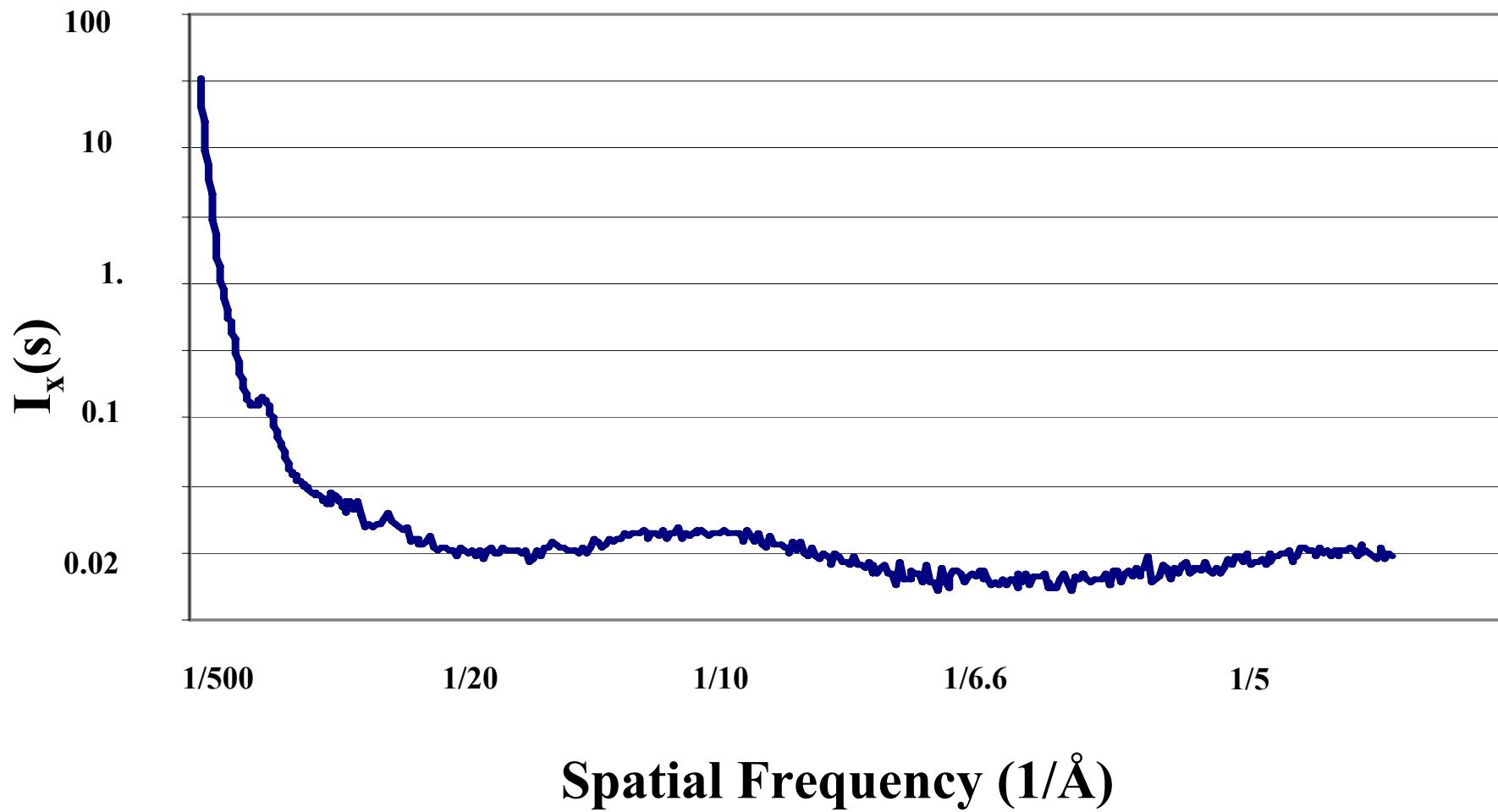


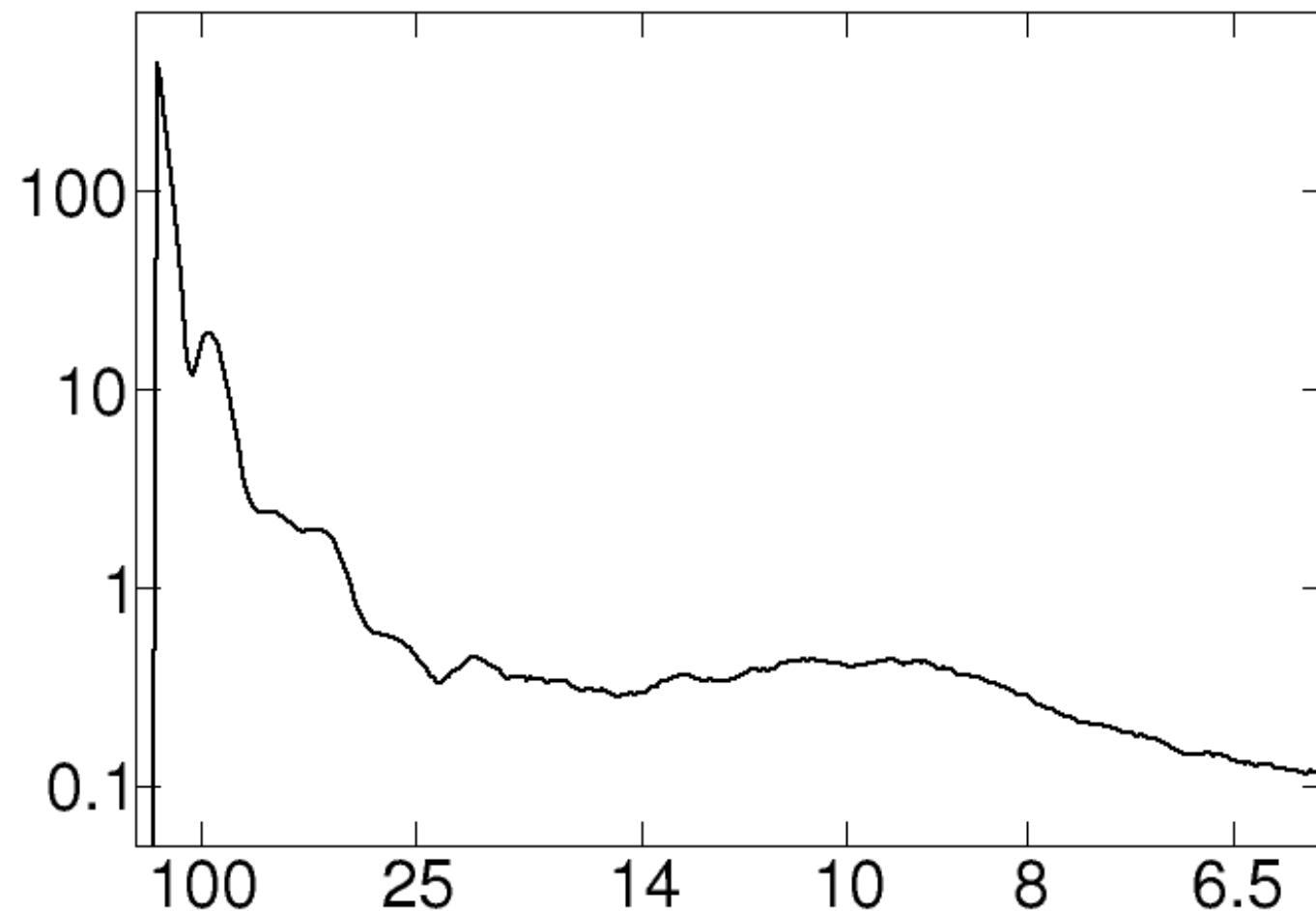
Figure 3.5. Change in the atomic scattering factor $f(\theta)$ with scattering angle θ (calculated from equation 3.10) showing that elastic scattering decreases with angle away from the incident beam direction ($\theta = 0^\circ$) and increases with Z .

X-ray Scattering Intensity of HSV-1 Capsids



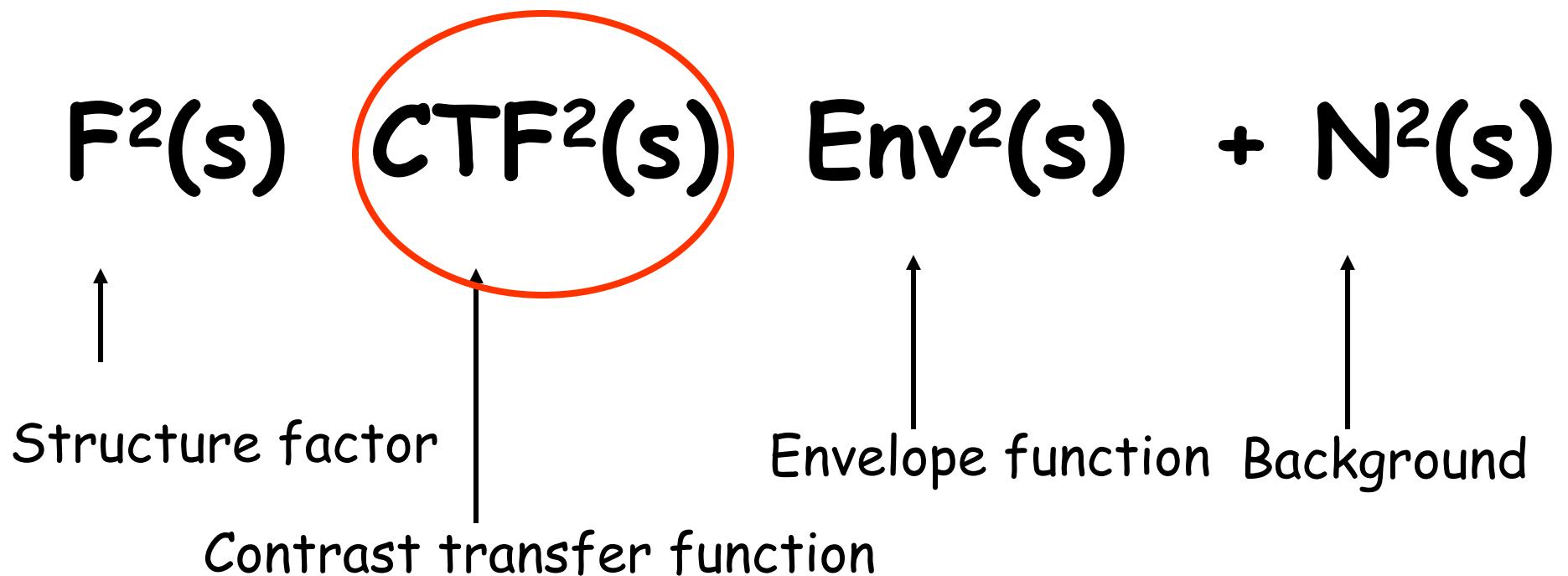
Dr. Hiro Tsuruta at SLAC

X ray Scattering Intensity of GroEL



Resolution (Å)

Computed diffraction pattern



Contrast Transfer Function

$$\text{CTF}(s) = -A [(1-Q^2)^{1/2} \sin(\gamma) + Q \cos(\gamma)]$$

$$\gamma(s) = -2\pi (C_s \lambda^3 s^4 / 4 - \Delta Z \lambda s^2 / 2)$$

ΔZ is vector dependent if there is an astigmatism

CTF Simulation - Microsoft Internet Explorer

File Edit View Favorites Tools Help

Back Search Favorites History

Address http://ncmi.bcm.tmc.edu/~wjiang/ctf Go

Home Research Photo

CTF Simulation

Publication: [Web-based Simulation for Contrast Transfer Function and Envelope Functions](#). Microscopy and Microanalysis 7(4), 329-334, 2001

Contrast of an electron image is influenced by the contrast transfer function (CTF) and the envelope functions of the electron microscope. In order to plan an experimental condition for data collection or to interpret the contrast of an electron micrograph, one would often need to know the quantitative values of these functions for a given set of microscope parameters. This simulation program is written in [Java](#) applet and [JavaScript](#) programming language. The parameters of these functions can be adjusted interactively with slider bars and the plot for the simulated function would be updated instantaneously.

This applet is known to run on Windows (Netscape and Internet Explorer), Linux (i386) (Netscape), SGI IRIX (Netscape), OS/2 Warp and MacOS X. Please inform me if you found that this applet runs or has problems to run on other platforms.

The following is the detailed descriptions for some aspects of the applet page.

List of the special symbols/functions used in the applet

Term	Unit	Description
s	1/ \AA	resolution
v	keV	accelerating voltage
C _s	mm	spherical aberration

m bcm148-147.alkek.dhcp.bcm.tmc.edu Welcomel friend fro Internet

CTF Simulation - Microsoft Internet Explorer - [Working Offline]

File Edit View Favorites Tools Help

Voltage(keV)

300

Cs(mm)

1.6

Cc(mm)

2.2

Energy spread(eV)

0.9

Lens current spread(ppm)

1

Vertical motion(Angstrom)

50

Drift(Angstrom)

0

$1/s = 10 \text{ A}$
 $f(s) = 0.1172$

-0.4

0.02 0.04 0.06 0.08 0.1 0.12 0.14 0.16 0.18

-0.4

-0.8

xmin

0

xmax

0.2

ymin

-1

ymax

1

Set Limits

Restore Limits

dZ(angstrom)



10000

B(angstrom^2)



0

Amp Contrast



0

Angle(mrad)



0.1

s(1/angstrom)



0.1

Enter a function f(s), which can use the variables(s,v,a,dZ,B,Cs,Cc,Q,dE,dI,dF,dR):

ctf(s,v,Cs,dZ,Q)

Plot

CTF Simulation - Microsoft Internet Explorer - [Working Offline]

File Edit View Favorites Tools Help

Voltage(keV)

300

Cs(mm)

1.6

Cc(mm)

2.2

Energy spread(eV)

0.9

Lens current spread(ppm)

1

Vertical motion(Angstrom)

50

Drift(Angstrom)

0

1/s = 10 A
f(s) = 0.2142

0.8

+0.4

0.02 0.04 0.06 0.08 0.1 0.12 0.14 0.16 0.18

-0.4

-0.8

xmin

xmax

ymin

ymax

Set Limits

Restore Limits

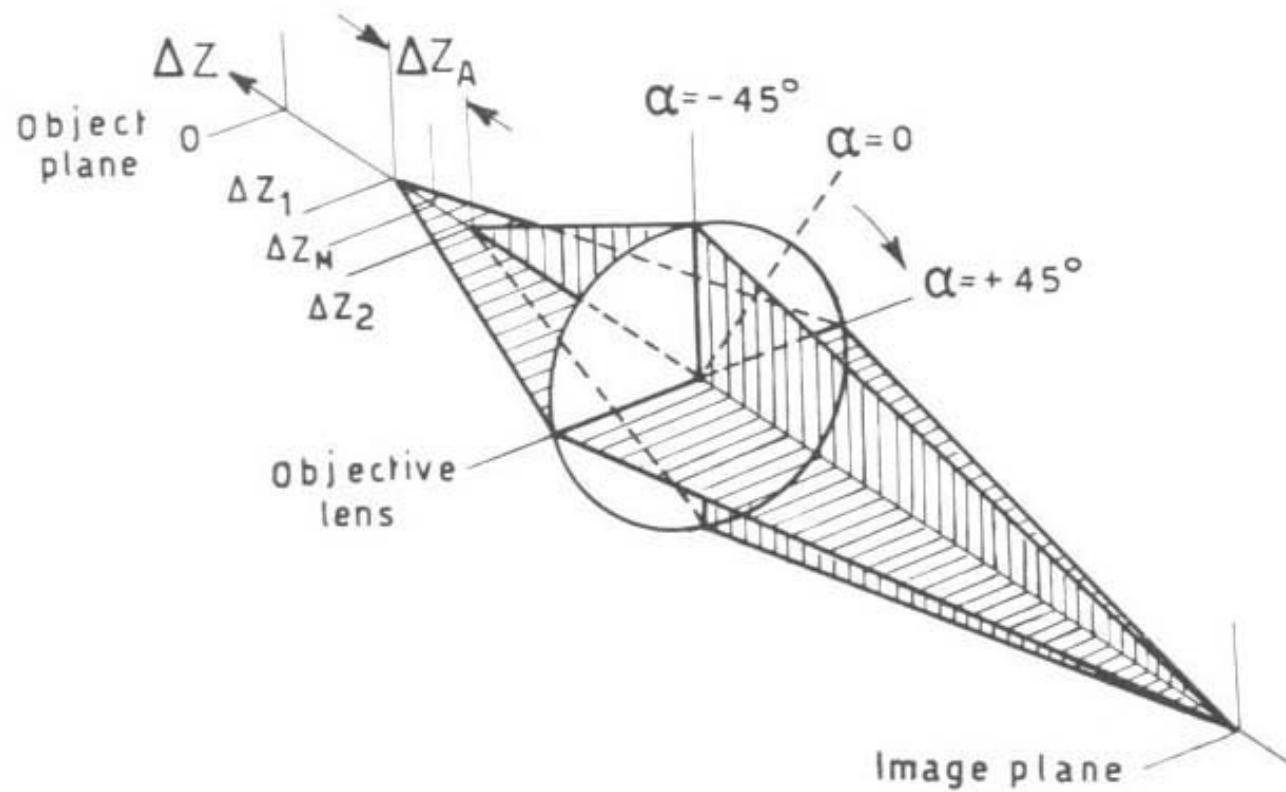
dZ(angstrom)	<input type="button" value="◀"/>	<input type="button" value="▶"/>	20000
B(angstrom ²)	<input type="button" value="◀"/>	<input type="button" value="▶"/>	100
Amp Contrast	<input type="button" value="◀"/>	<input type="button" value="▶"/>	0
Angle(mrad)	<input type="button" value="◀"/>	<input type="button" value="▶"/>	0.1
s(1/angstrom)	<input type="button" value="◀"/>	<input type="button" value="▶"/>	0.1

Enter a function f(s), which can use the variables(s,v,a,dZ,B,Cs,Cc,Q,dE,dI,dF,dR):

ctf(s,v,Cs,dZ,Q)

Plot

Astigmatism



From F. Thon

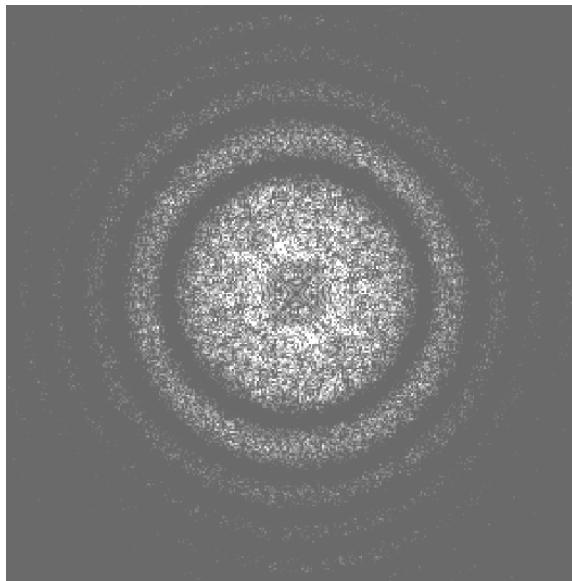
Astigmatism

$$\Delta Z_{\text{eff}}(\alpha) = \Delta Z_m + (\Delta Z_a \sin 2\alpha)/2$$

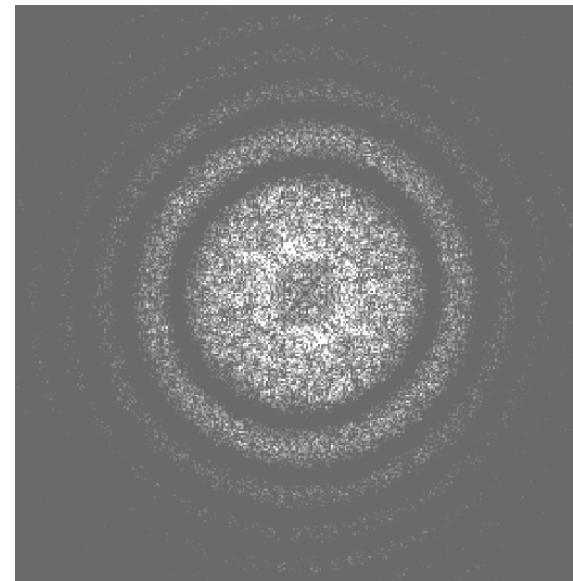
$$\Delta Z_m = (\Delta Z_1 + \Delta Z_2)/2$$

$$\Delta Z_a = \Delta Z_1 - \Delta Z_2$$

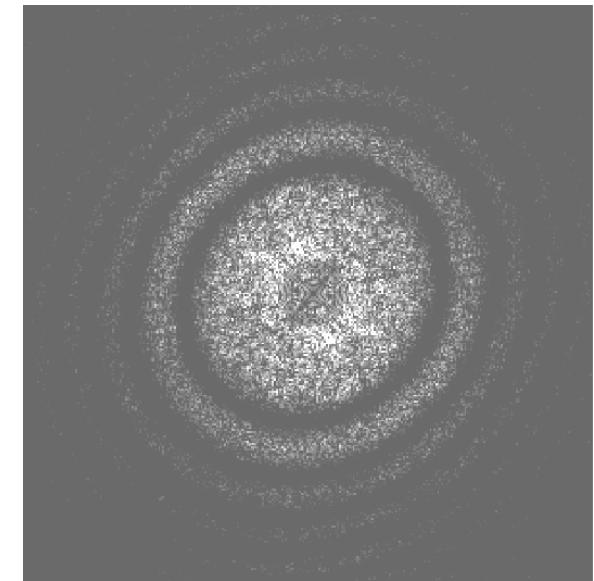
Synthetic Power Spectrum $\Delta Z = 0.8 \mu\text{m}$



Astigmatism
amplitude =
 $0.0 \mu\text{m}$

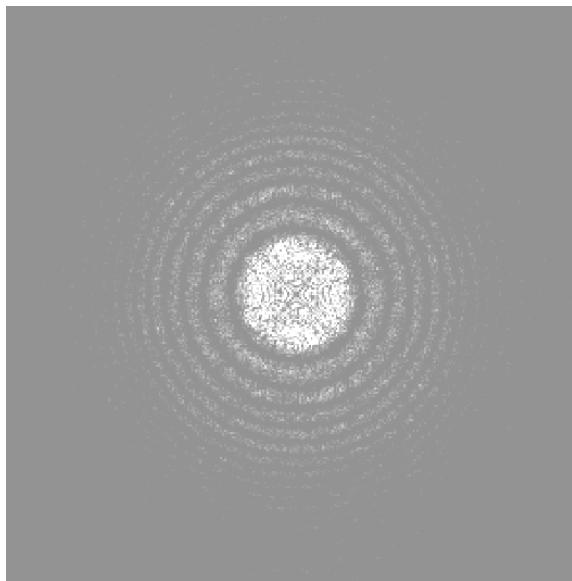


Astigmatism
amplitude =
 $0.0267 \mu\text{m}$

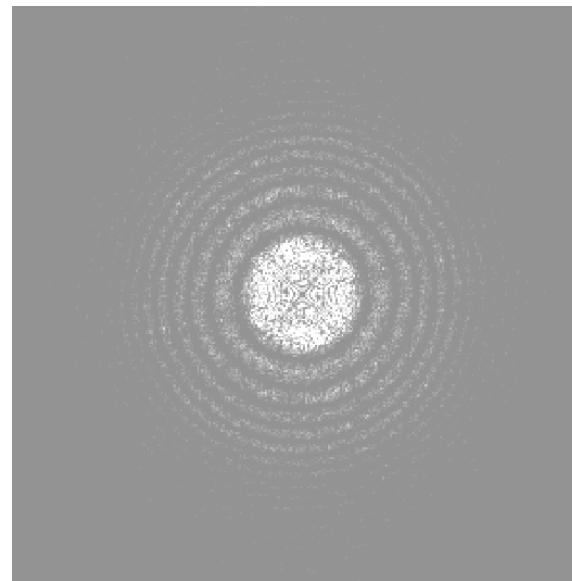


Astigmatism
amplitude =
 $0.1 \mu\text{m}$

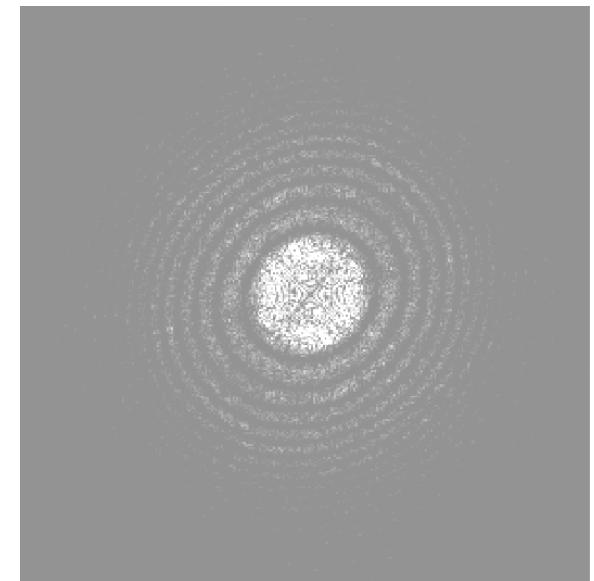
Synthetic Power Spectrum $\Delta Z = 3 \mu\text{m}$



Astigmatism
amplitude =
 $0.0\mu\text{m}$

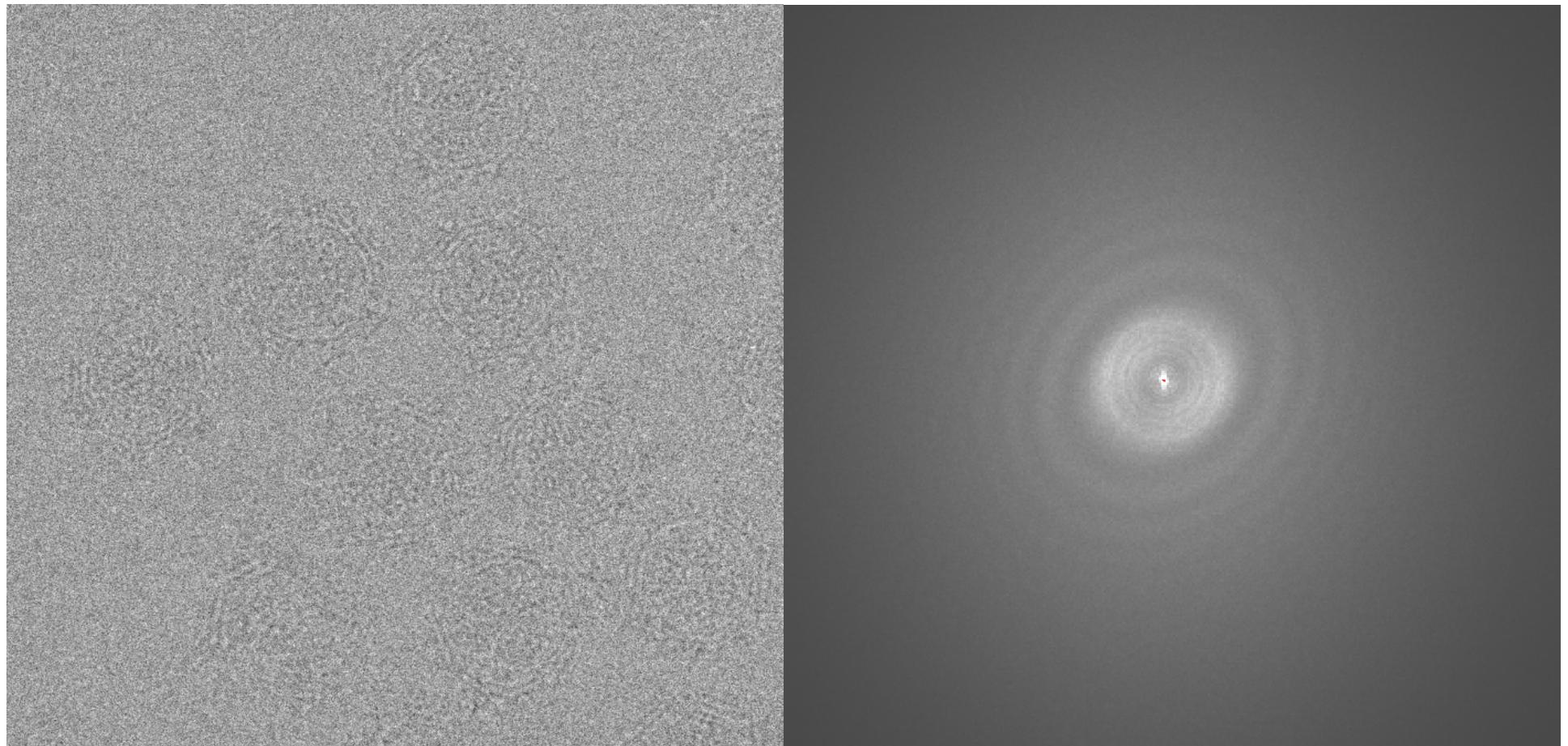


Astigmatism
amplitude =
 $0.1\mu\text{m}$



Astigmatism
amplitude =
 $0.375\mu\text{m}$

Astigmatism in Single Particle Image



From Dr. Angel Paredes

Computed diffraction pattern

$$F^2(s) \quad CTF^2(s) \quad Env^2(s) + N^2(s)$$

The diagram illustrates the components of a computed diffraction pattern. It consists of four terms separated by plus signs: $F^2(s)$, $CTF^2(s)$, $Env^2(s)$, and $N^2(s)$. Below each term is a vertical arrow pointing upwards, indicating the input source for that component. The first two arrows point to the left, while the last two point to the right. The term $Env^2(s)$ is circled in red, highlighting it as a key component.

↑
Structure factor ↑
Contrast transfer function

↑
Envelope function

↑
Background

EM Envelope Functions : Env(s)

Gaussian type source:

$$G_{sc}(s) = \exp[-\pi^2 \alpha^2 (C_s \lambda^2 s^3 - \Delta Z_s)^2]$$

Gaussian type fluctuation:

$$G_{tc}(s) = \exp\left[-\frac{\pi^2}{16 \ln 2} C_C^2 \lambda^2 \left(\frac{\Delta E}{E}\right)^2 s^4\right]$$

Gaussian type fluctuation:

$$G_{ol}(s) = \exp\left[-\frac{\pi^2}{4 \ln 2} C_C^2 \lambda^2 \left(\frac{\Delta I}{I}\right)^2 s^4\right]$$

Sinusoidal type fluctuation:

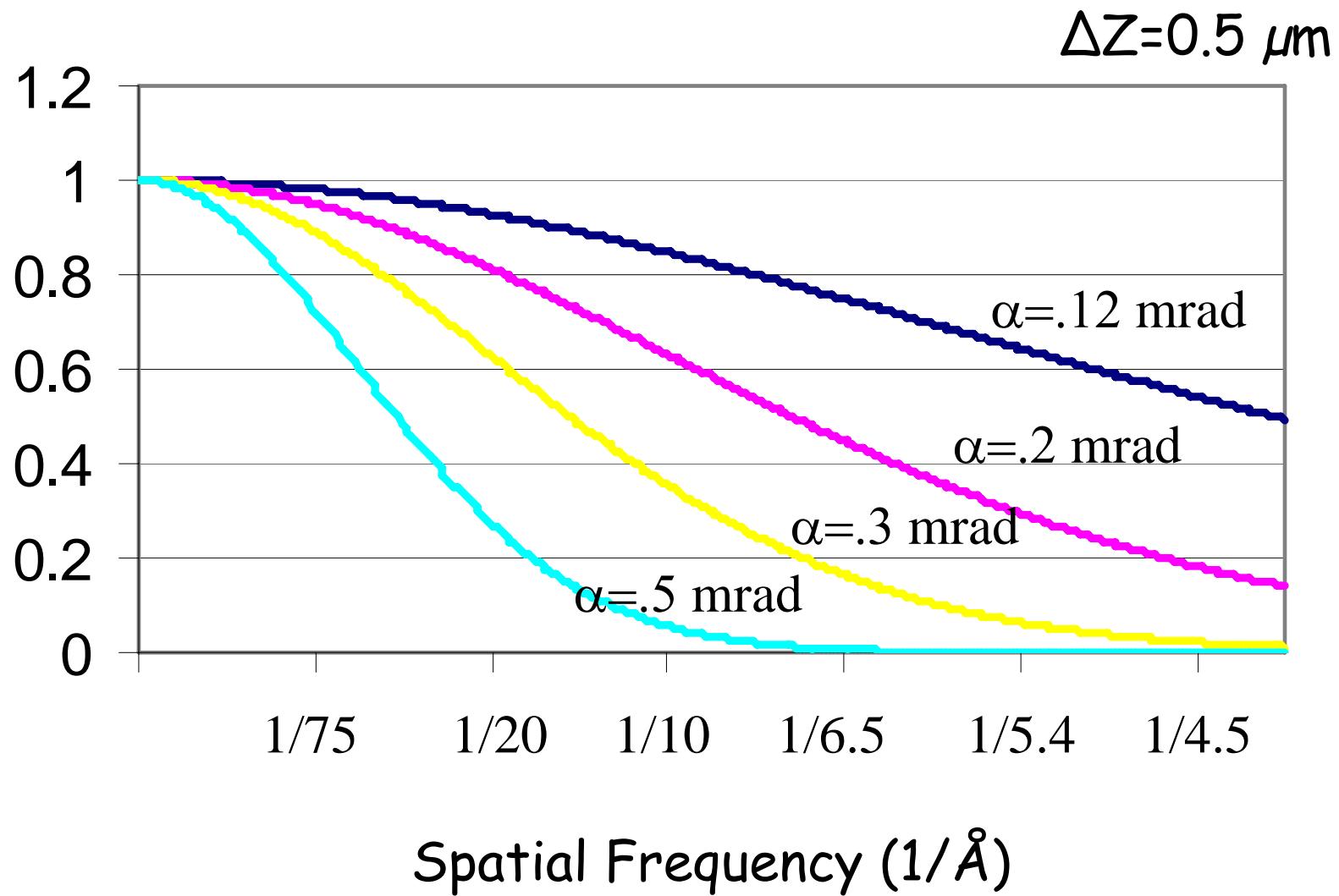
$$G_{lm}(s) = J_0(\pi \Delta f \lambda s^2)$$

Drift:

$$G_{tm}(s) = \frac{\sin(\pi s \Delta r)}{\pi s \Delta r}$$

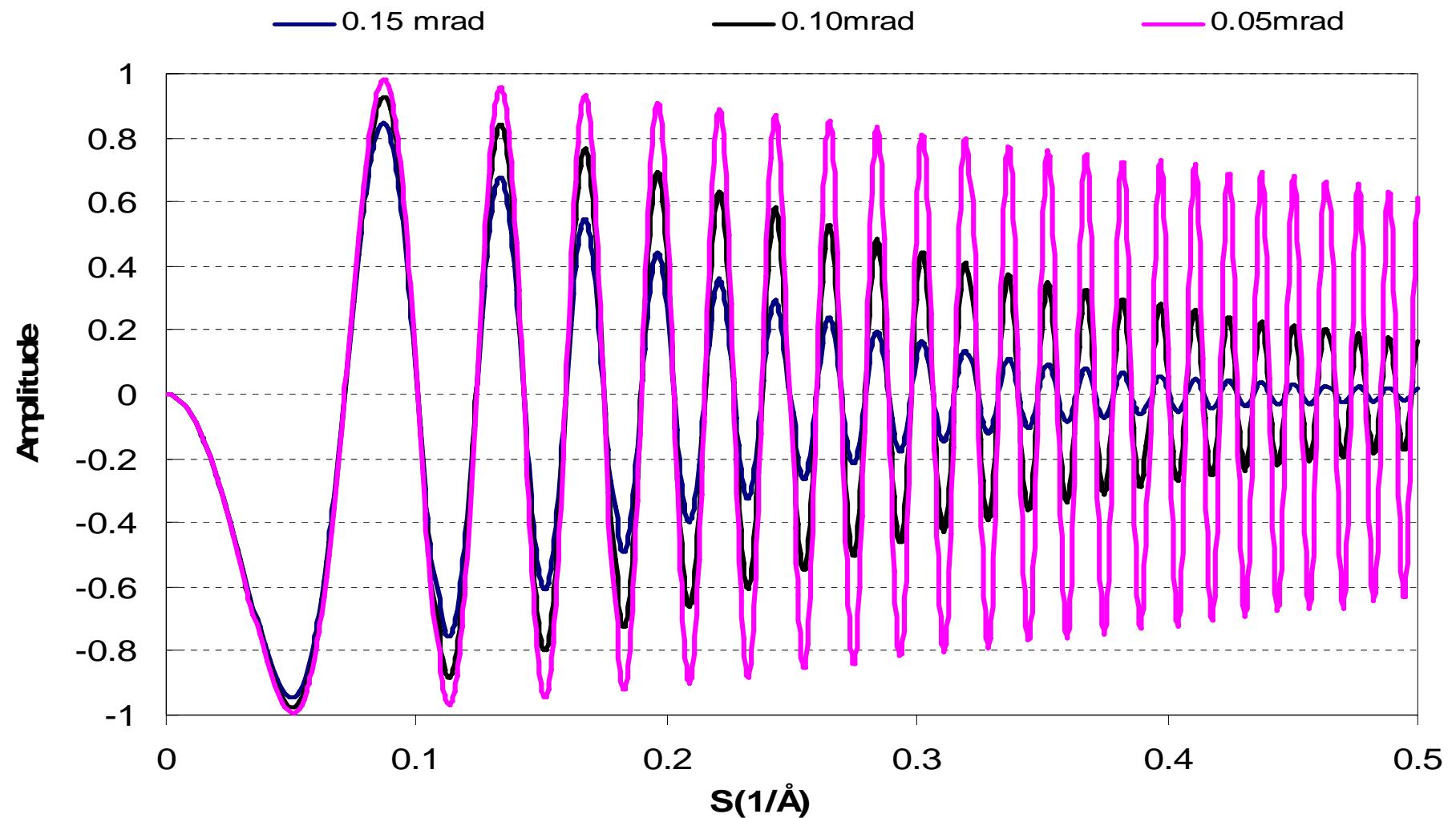
Chiu Scanning Electron Microsc. 1:569-580 (1978)

Spatial coherence envelope function



300 keV, $C_s = 1.6$ mm, defocus = 1 μM

CTF curve at different illumination angle



EM Envelope Functions : Env(s)

Gaussian type source:

$$G_{sc}(s) = \exp[-\pi^2 \alpha^2 (C_s \lambda^2 s^3 - \Delta Z_s)^2]$$

Gaussian type fluctuation:

$$G_{tc}(s) = \exp\left[-\frac{\pi^2}{16 \ln 2} C_C^2 \lambda^2 \left(\frac{\Delta E}{E}\right)^2 s^4\right]$$

Gaussian type fluctuation:

$$G_{ol}(s) = \exp\left[-\frac{\pi^2}{4 \ln 2} C_C^2 \lambda^2 \left(\frac{\Delta I}{I}\right)^2 s^4\right]$$

Sinusoidal type fluctuation:

$$G_{lm}(s) = J_0(\pi \Delta f \lambda s^2)$$

Drift:

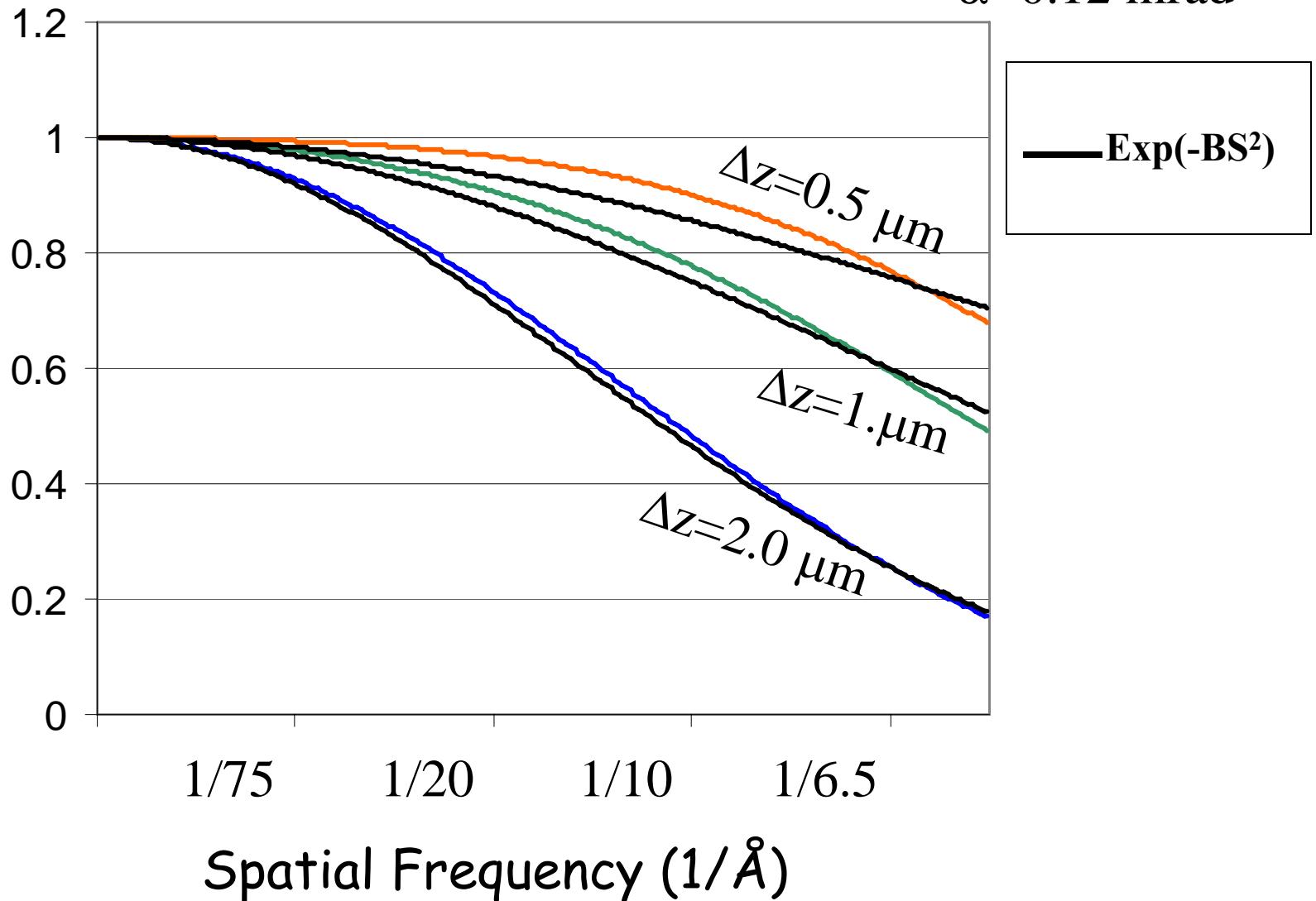
$$G_{tm}(s) = \frac{\sin(\pi s \Delta r)}{\pi s \Delta r}$$

Gaussian Approximation for Cumulative Envelope Function

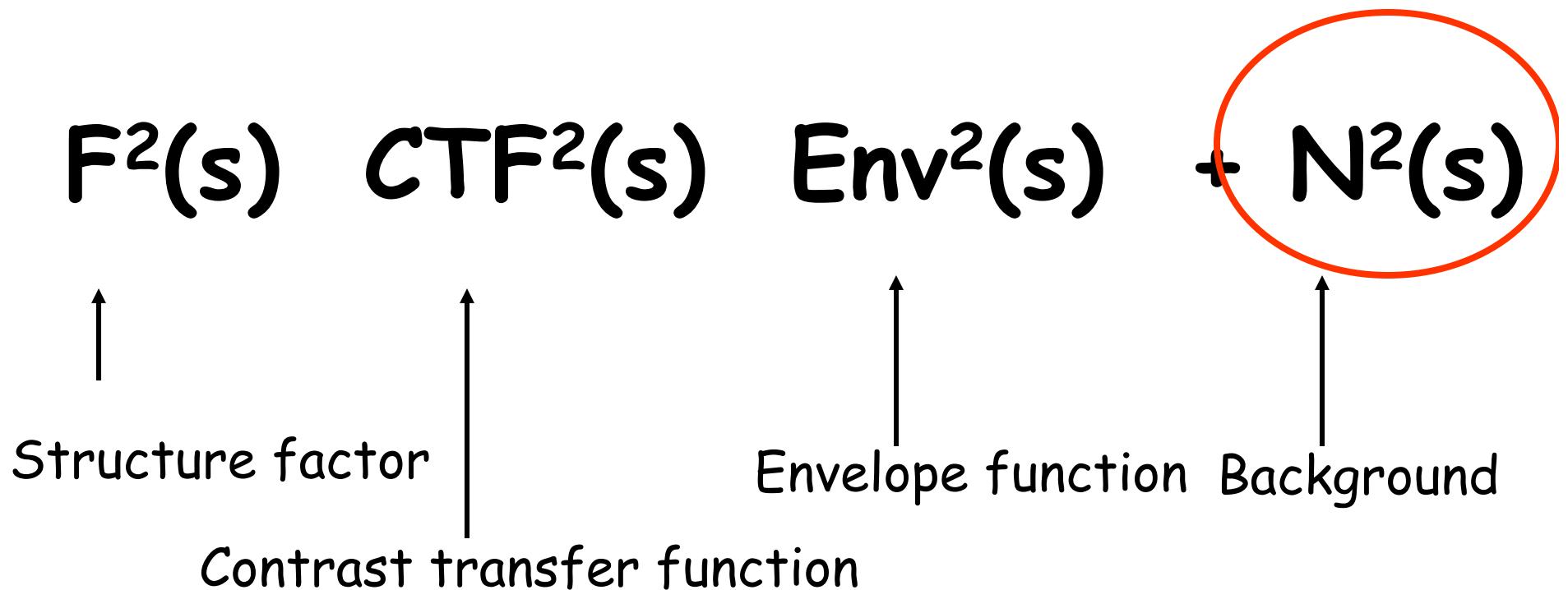
$$\text{Env}^2(s) \sim \exp(-2BS^2)$$

Fitting the spatial coherence envelope function with $\exp(-BS^2)$

$\alpha=0.12$ mrad

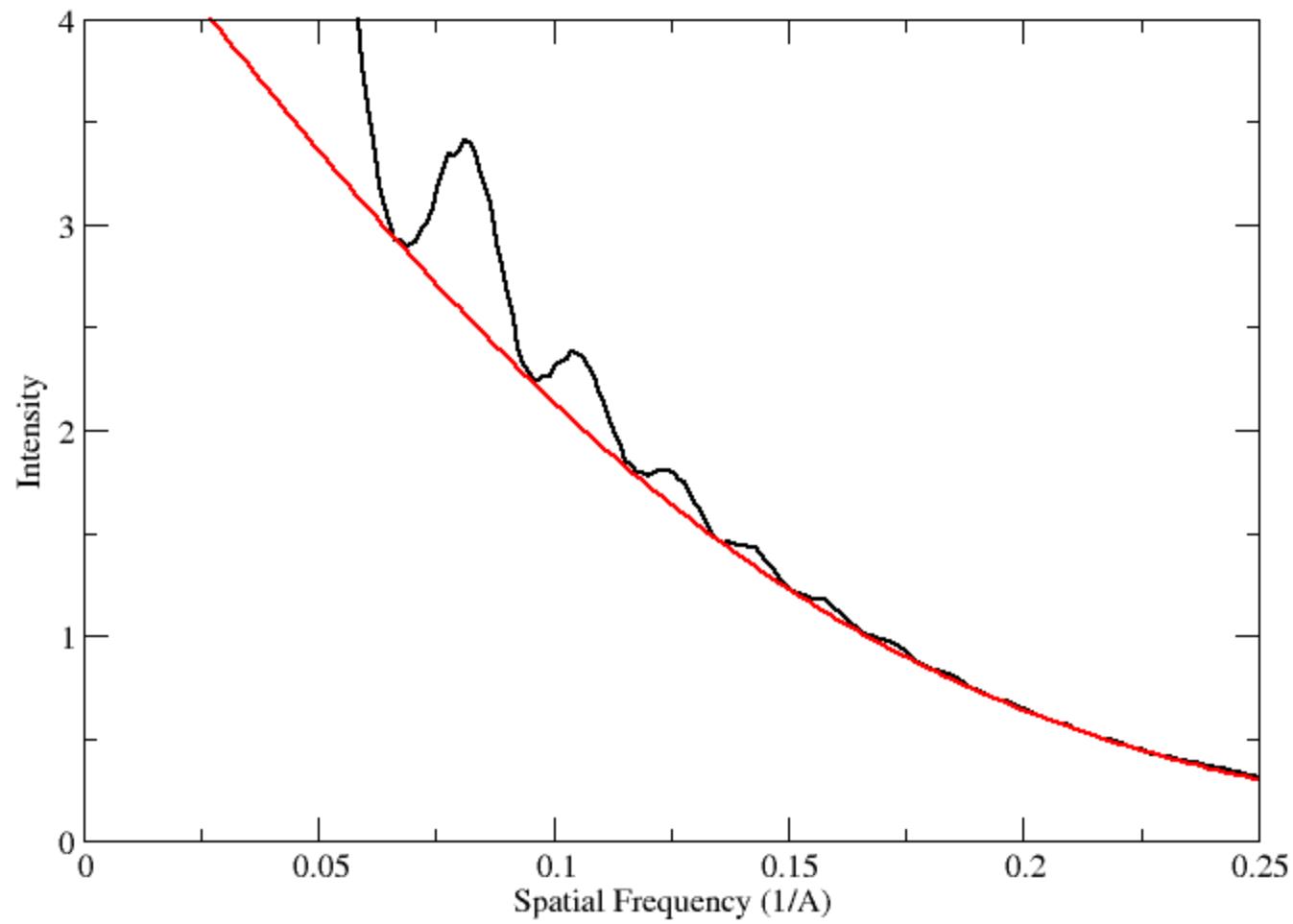


Computed diffraction pattern



Noise Function

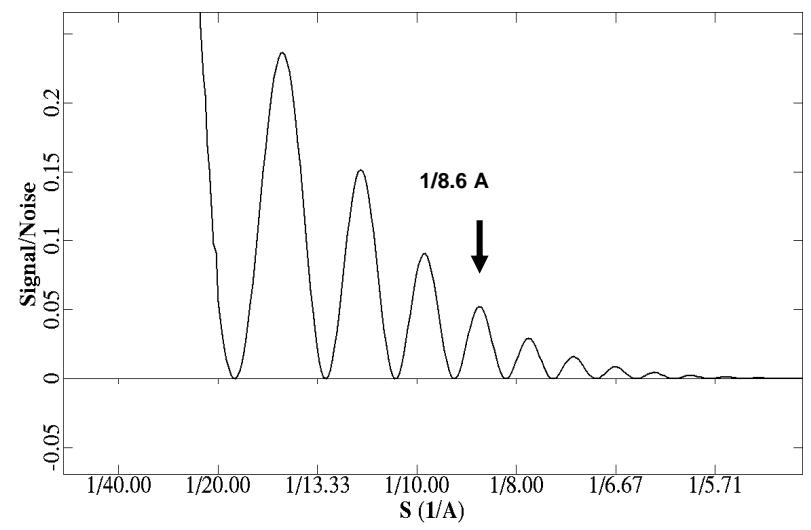
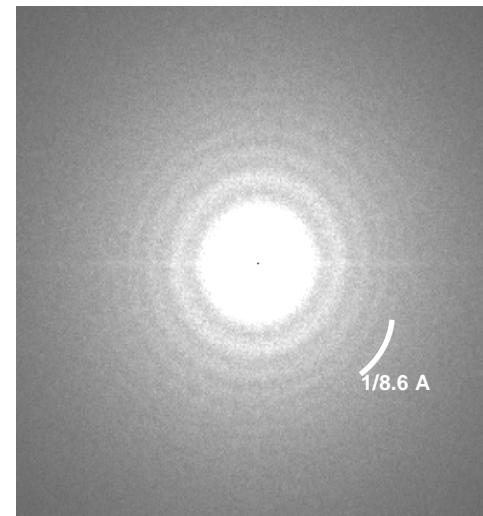
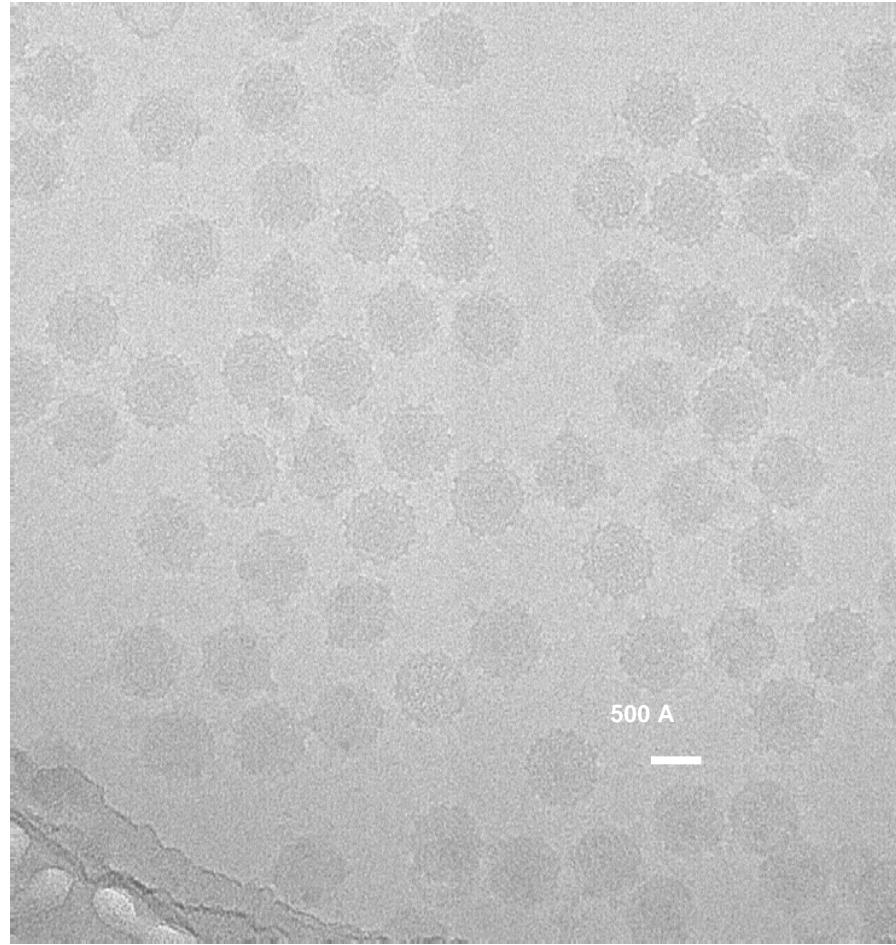
$$N^2(s) = n_1 \exp(n_2 s + n_3 s^2 + n_4 s^{1/2})$$



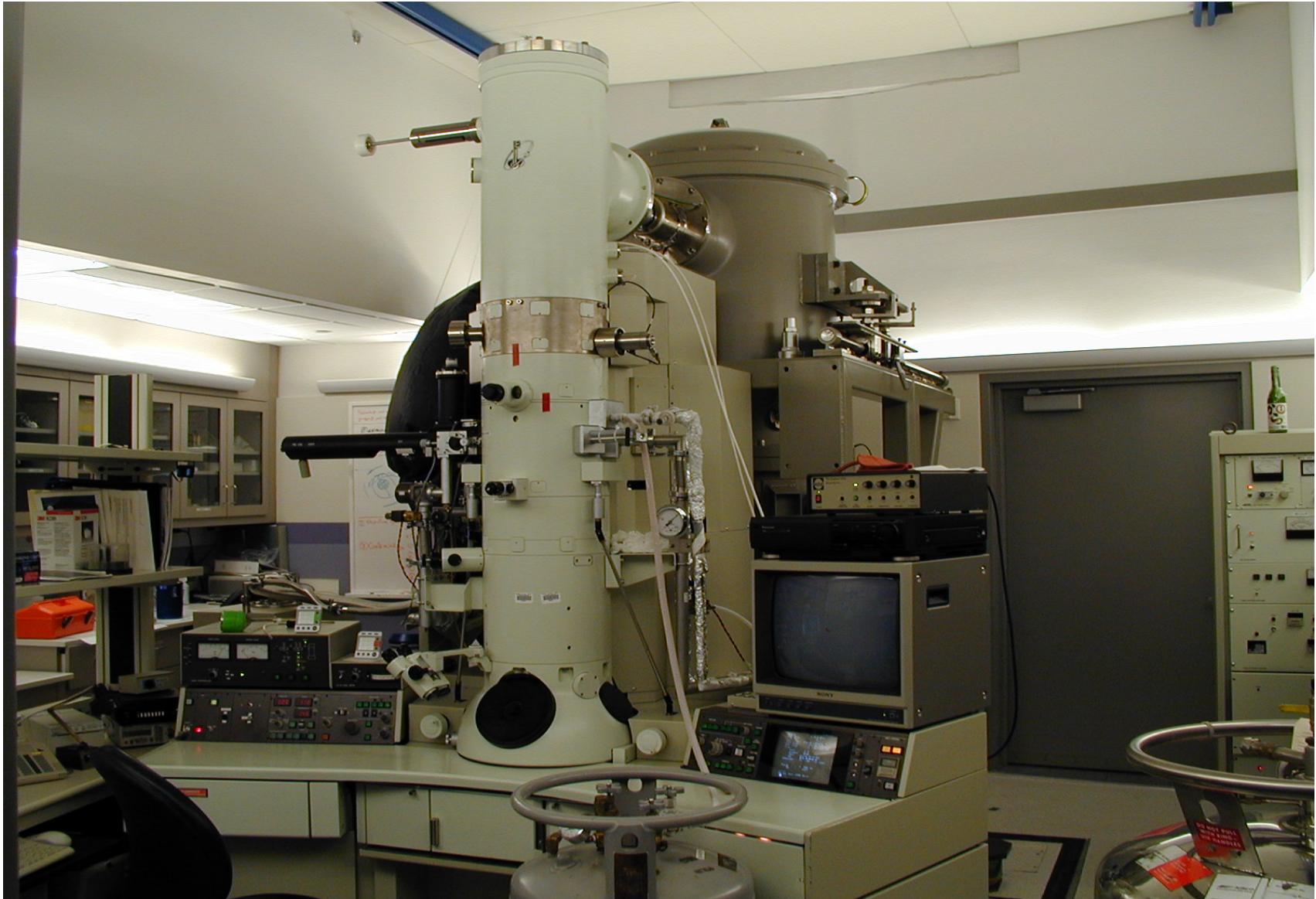
From Dr. Z. Li

$$\text{Contrast} = (F^2 \cdot CTF^2 \cdot E^2) / N^2$$

200kV Image and Power Spectrum of CPV

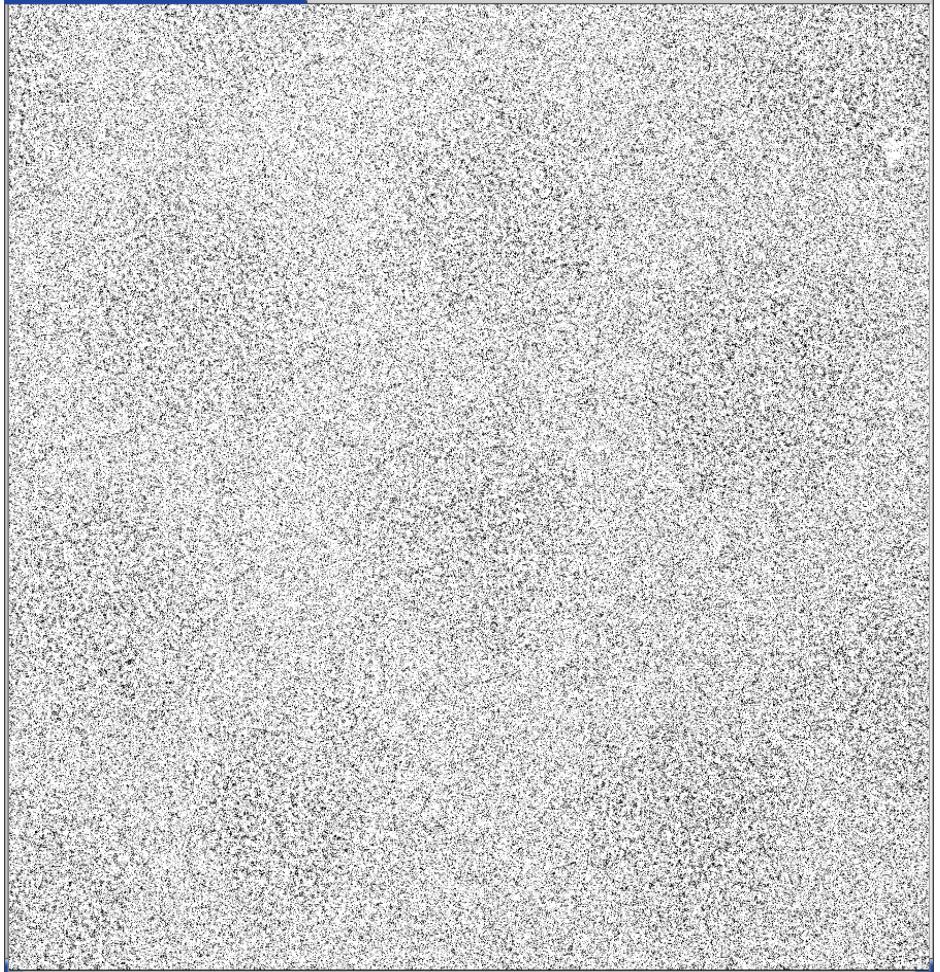


Booth JSB 2004

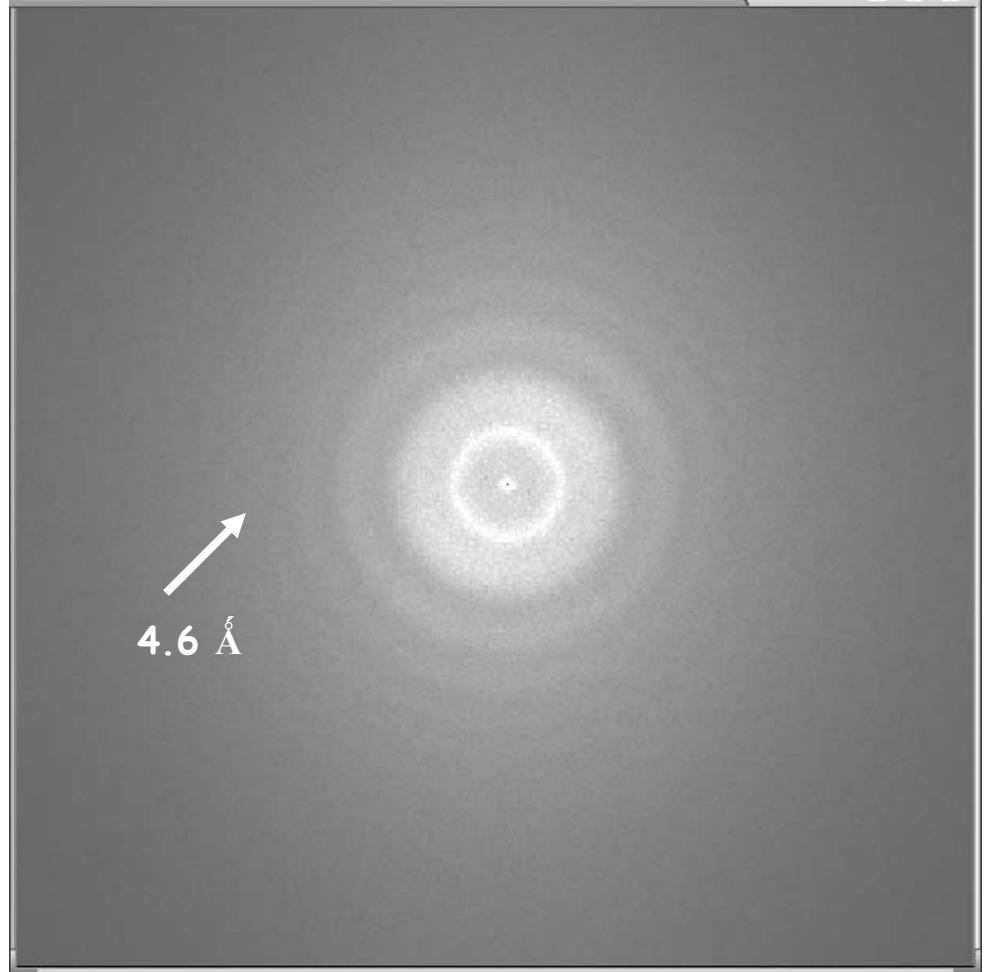


JEOL 3000SFF electron cryomicroscope at NCMI
equipped with liquid helium stage and field emission gun

300kV Image

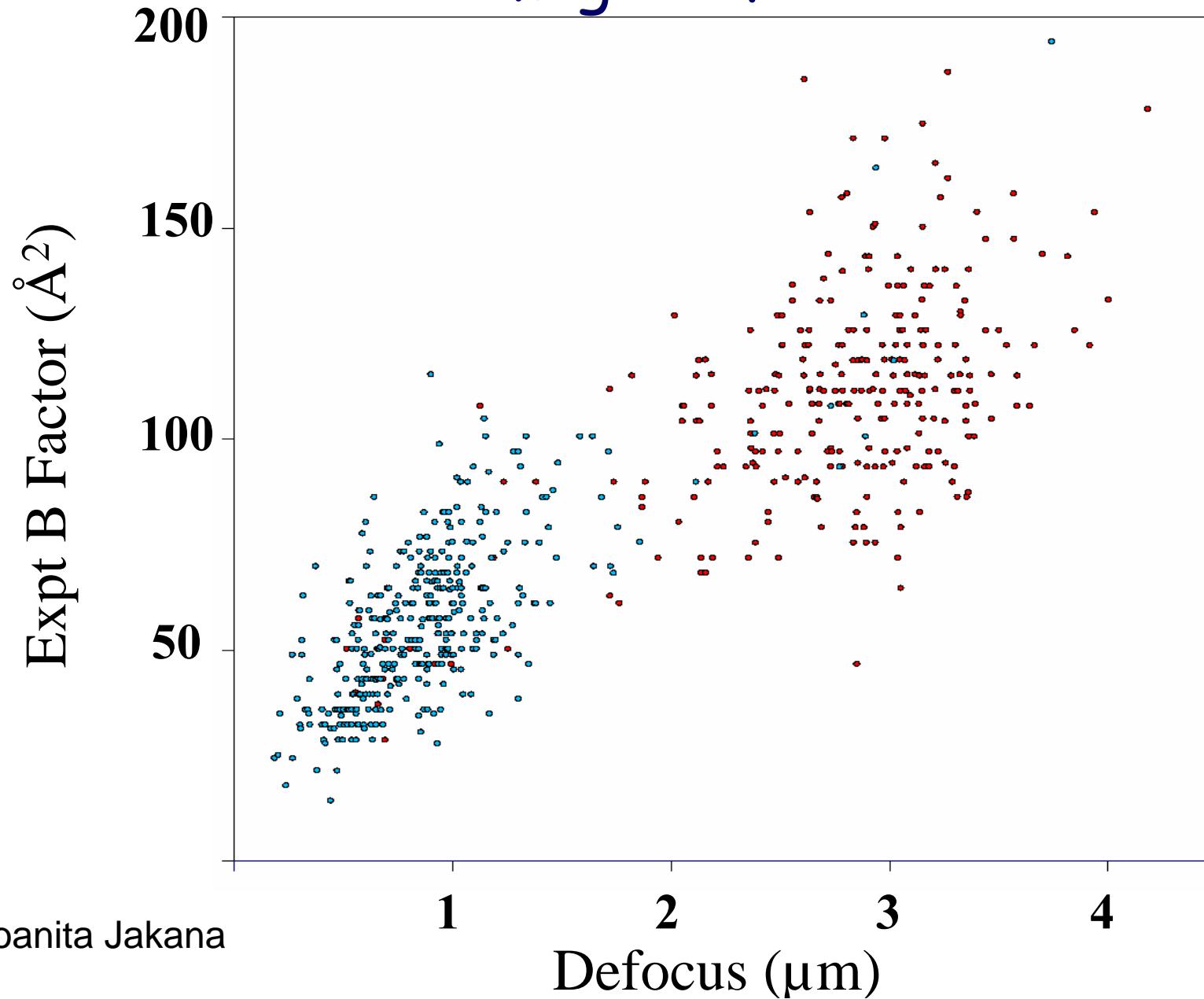


Power Spectrum



156 particles, $\Delta Z = 0.60 \mu\text{m}$
Joanita Jakana, MSA Proceeding, 2004

Experimental B factor vs defocus for 300 kV Images of CPV

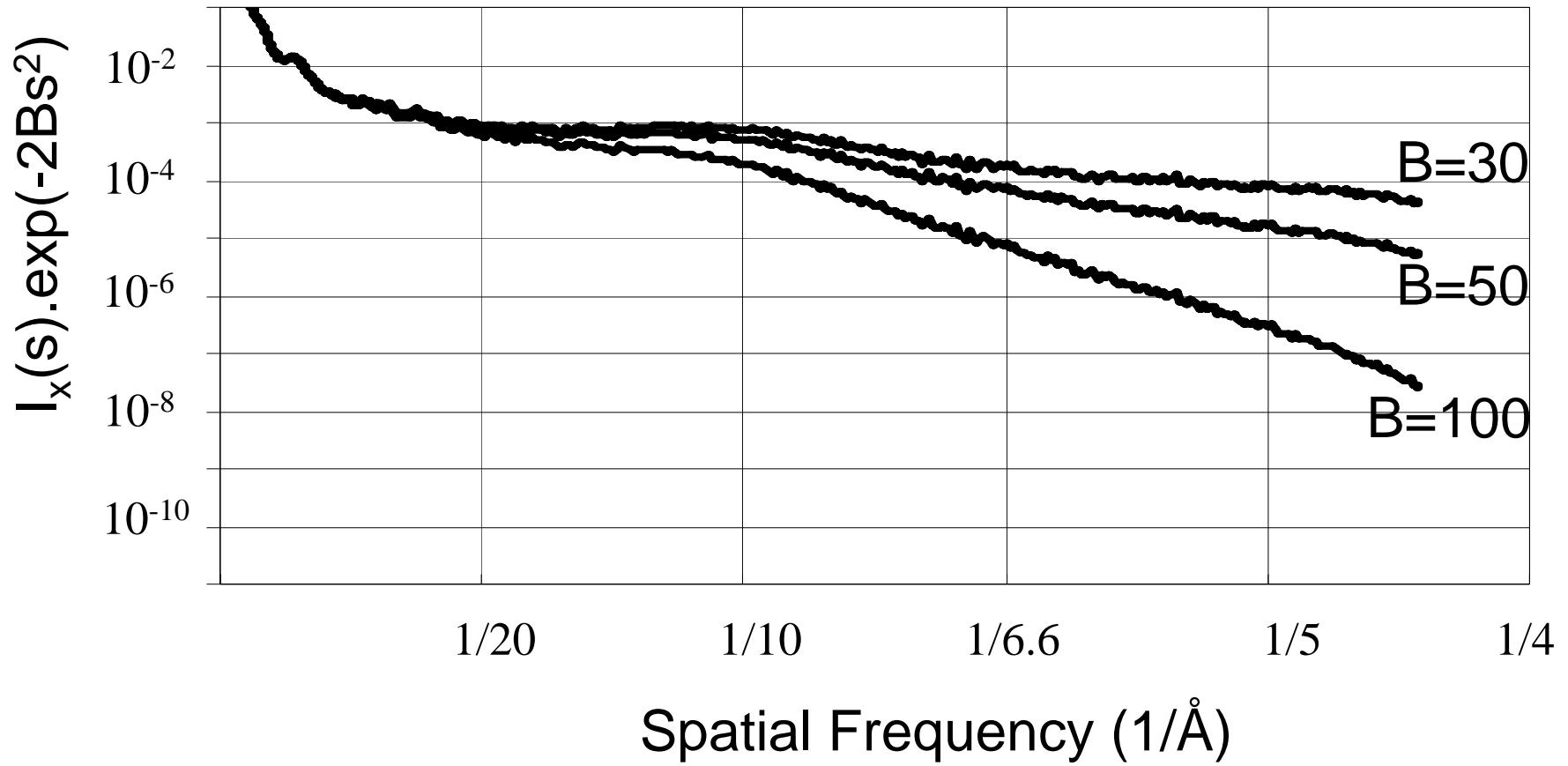


Joanita Jakana

Number of particles

required for a 3-D reconstruction is
inversely proportional to

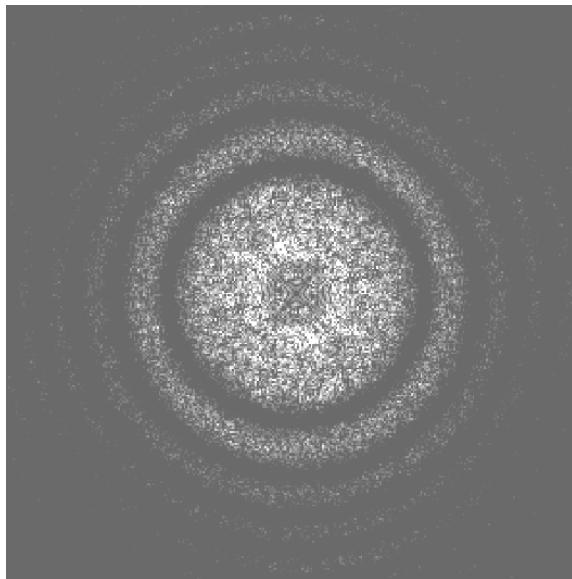
$$F^2(S) \exp(-2BS^2)$$



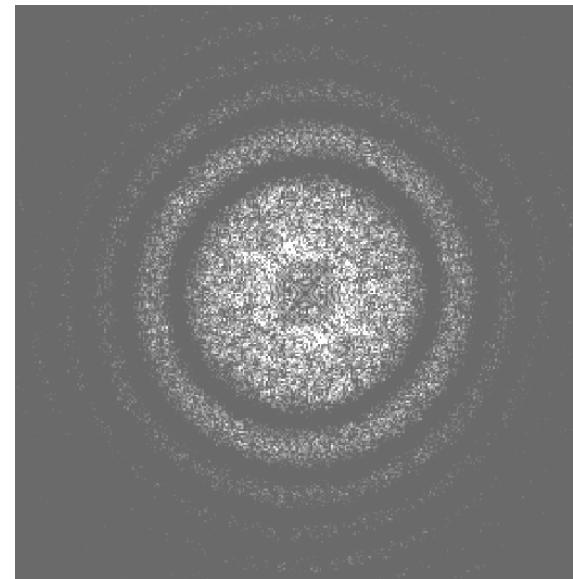
Causes of High B-Factor

- Large angle of illumination (defocus dependent)
- Astigmatism (defocus independent)
- Local specimen movement (defocus independent)
- Insufficient sampling (defocus independent)

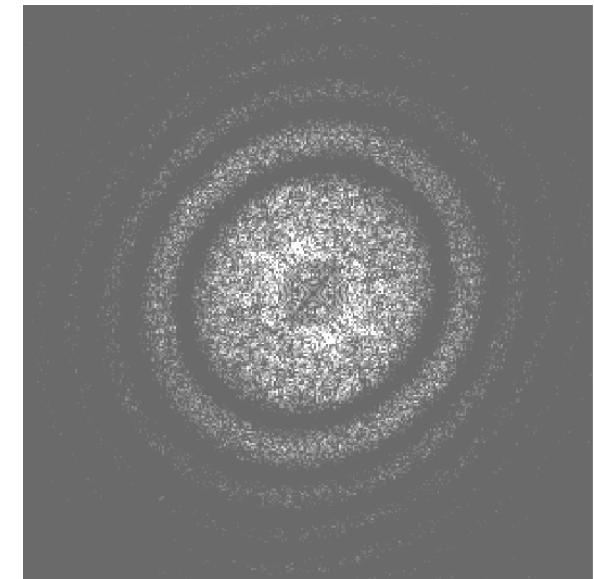
Synthetic Power Spectrum $\Delta Z = 0.8 \mu\text{m}$



Astigmatism
amplitude =
 $0.0 \mu\text{m}$



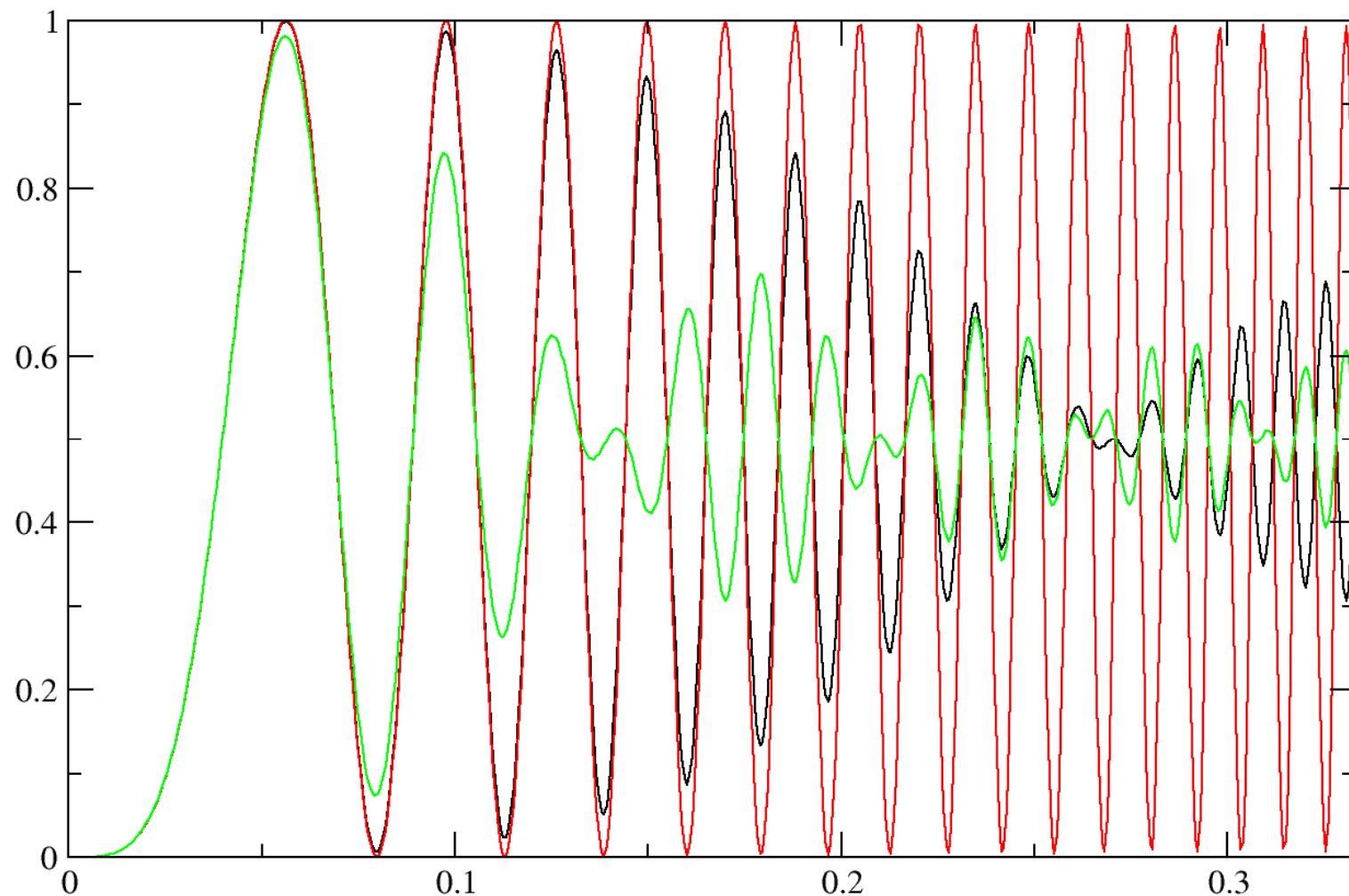
Astigmatism
amplitude =
 $0.0267 \mu\text{m}$



Astigmatism
amplitude =
 $0.1 \mu\text{m}$

$300\text{kV}, Cs=1.6\text{mm}$

$\Delta Z = 0.8 \mu\text{m}$ astigmatism = $0.0 \mu\text{m}, 0.0267 \mu\text{m}, 0.1 \mu\text{m}$

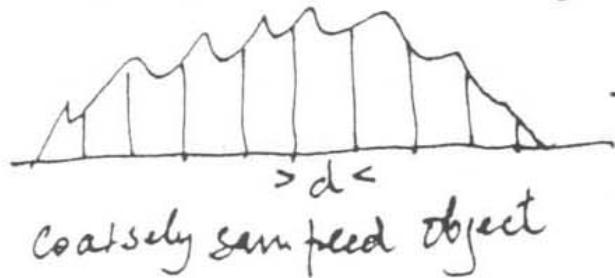


Sampling

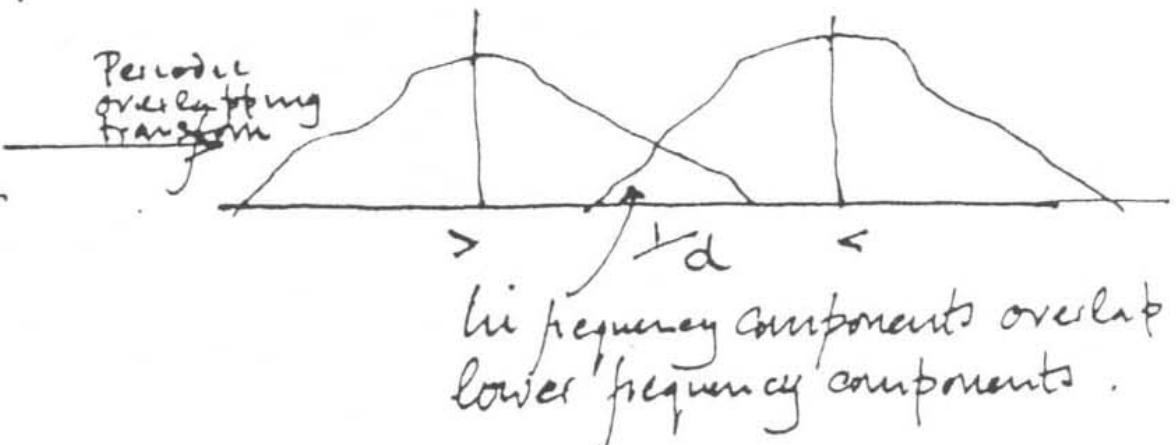
- Sampling distance in real space :
 $\Delta x = \frac{1}{2} - 1/3$ expected resolution
- Sampling distance in Fourier space
 $\Delta S = 1/(N \Delta x)$
- Choice of sampling (Δx) and box size (N) depends on expected resolution and the defocus used

Shannon - Nyquist sampling and aliasing.

Hence if object density contains fine details out to a spatial frequency $\frac{1}{2d}$ (ie spatial period $2d$) then sampling must not be coarser than d , otherwise neighbouring copies of the periodic transform begin to overlap. If the overlap were severe, high frequency terms from one copy of the transform overlap and contaminate low frequencies of the next, ie high frequencies would masquerade as low ones. This is known as aliasing.

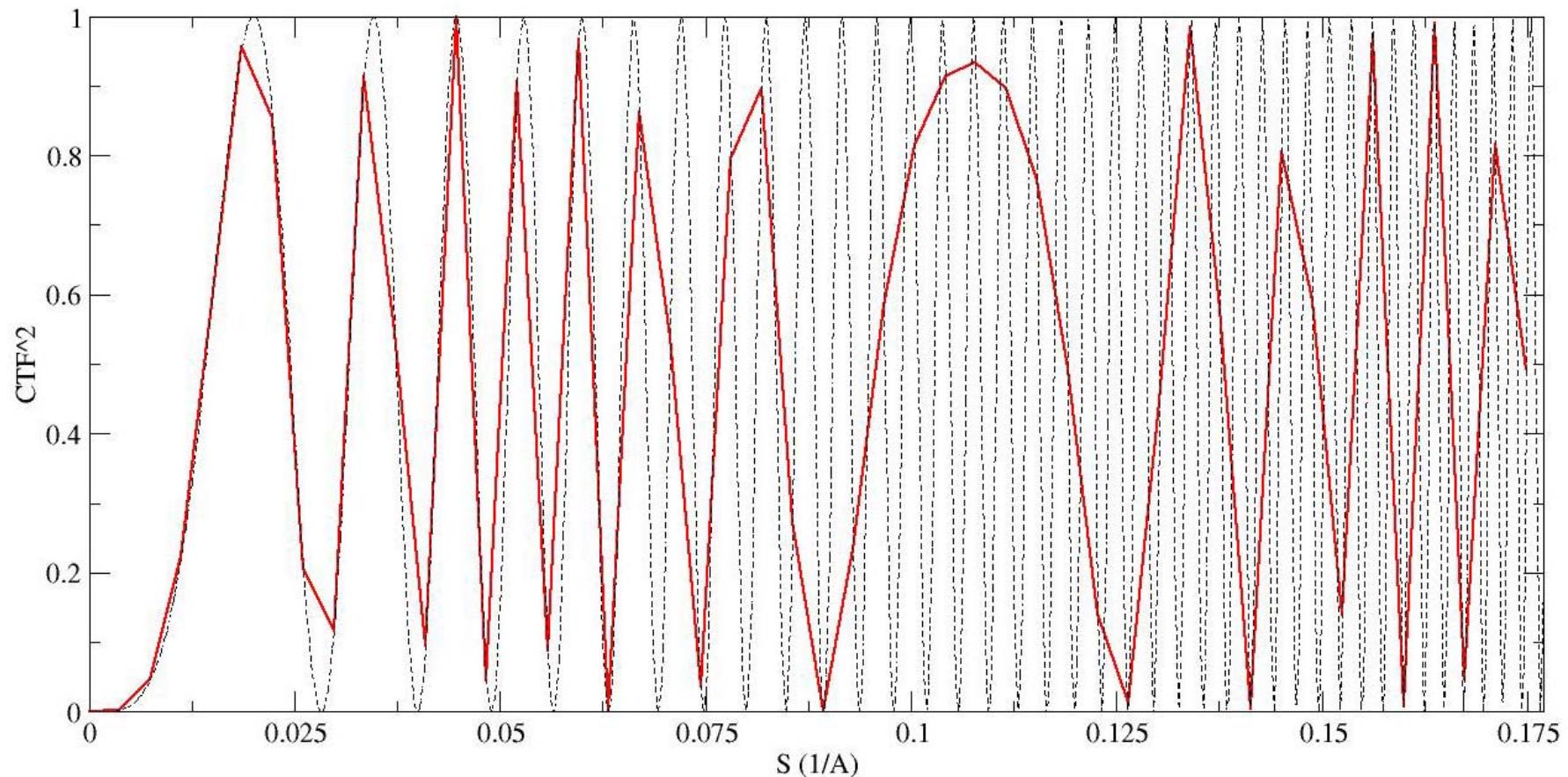


coarsely sampled object



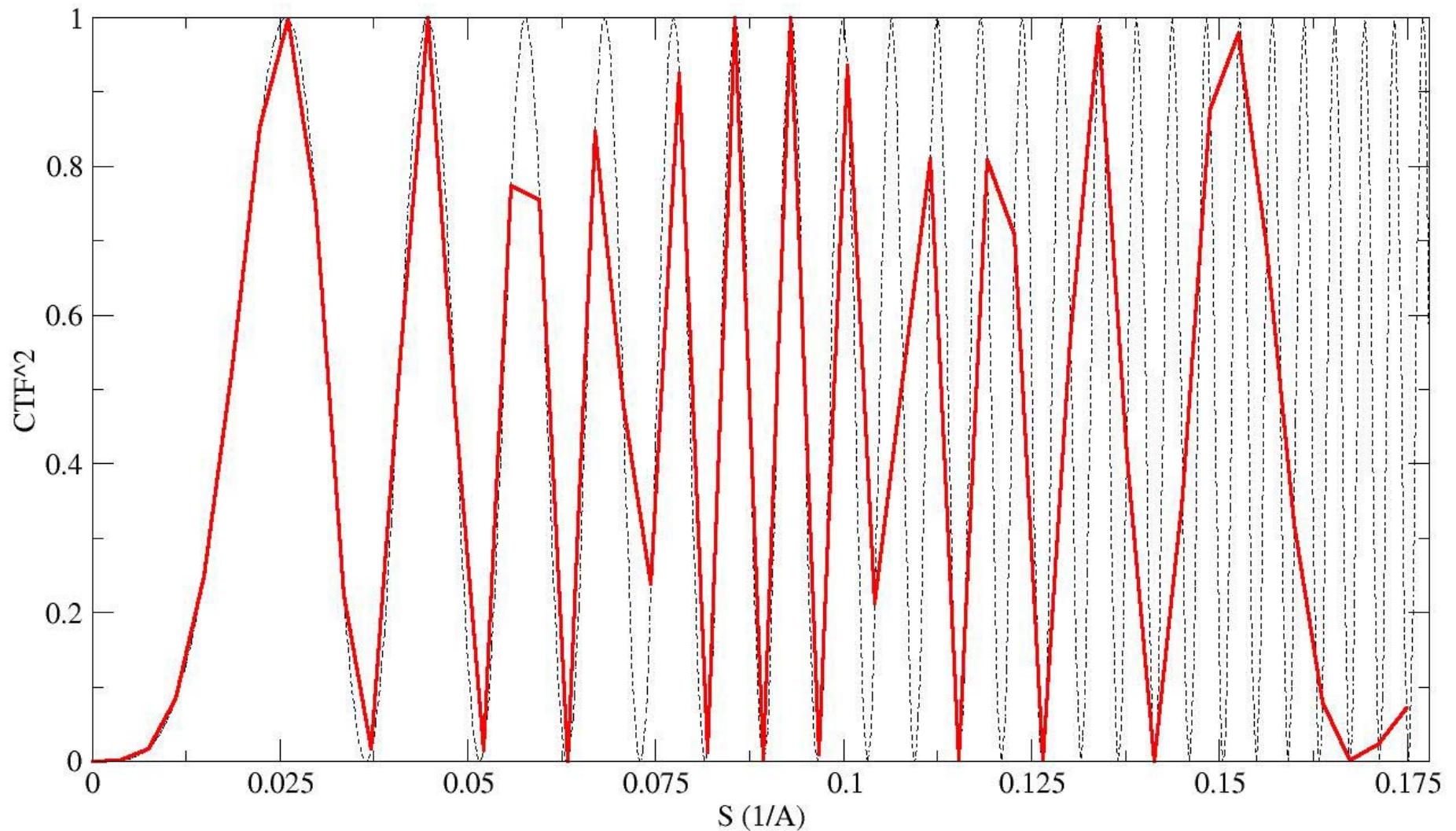
From Tony Crowther, MRC

Effect of Box Size on CTF Appearance



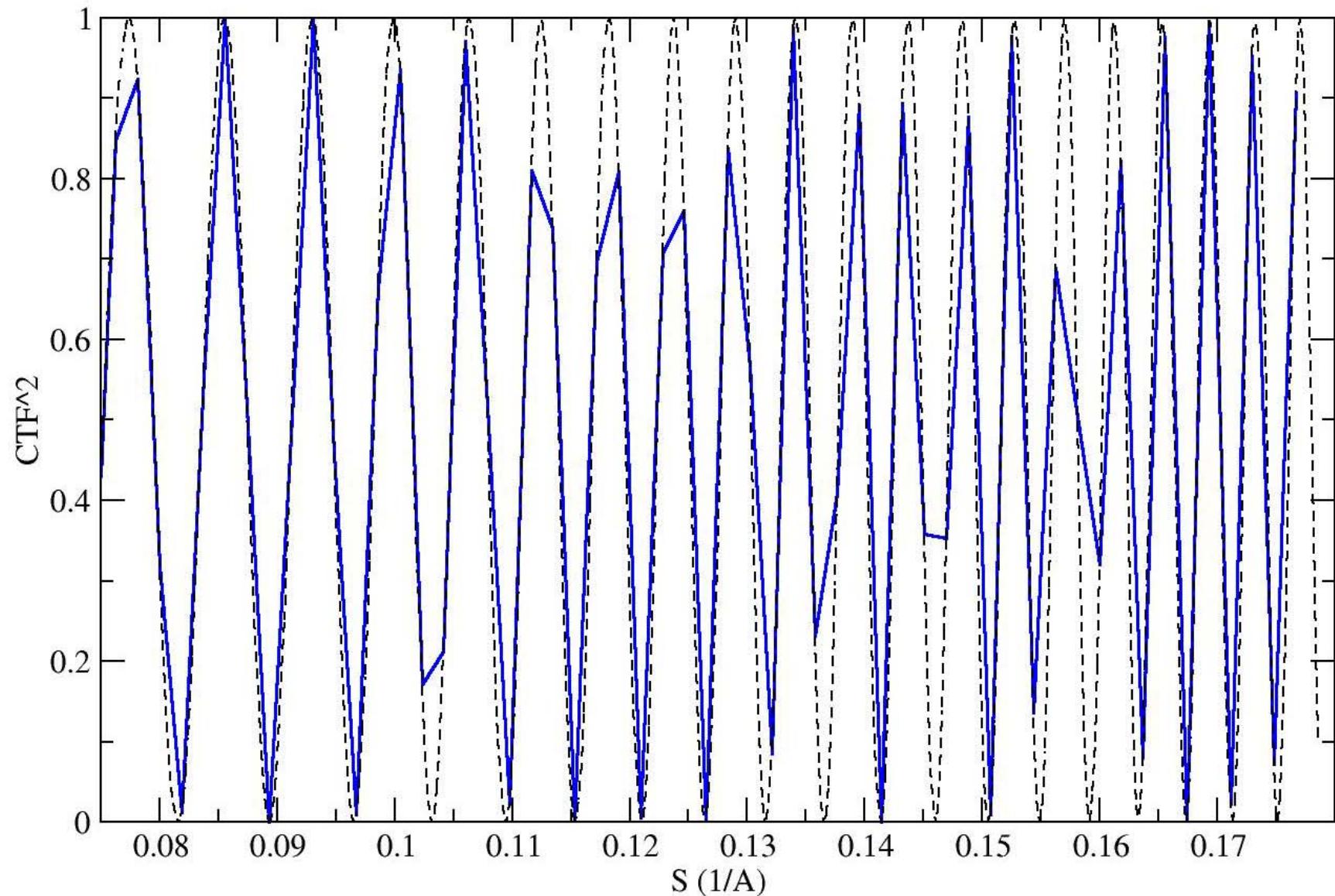
200 kV, $C_s = 1.2\text{mm}$, 2.8 \AA/pixel . 96x96 pixels box, $\Delta Z=5 \mu\text{m}$

Effect of Box Size on CTF Appearance



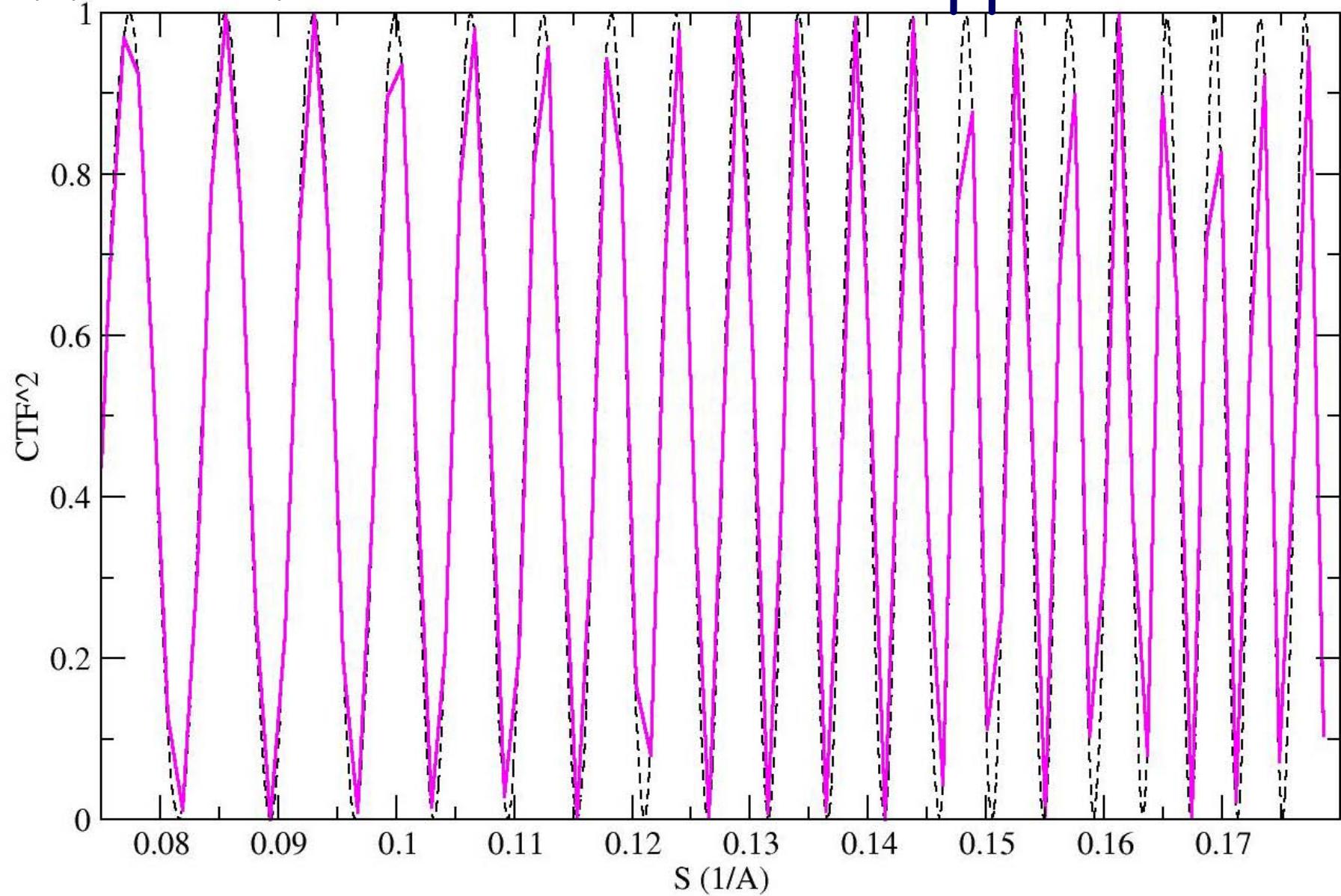
200 kV, $C_s = 1.2\text{mm}$, 2.8 \AA/pixel . 96×96 pixels box, $\Delta Z = 3 \mu\text{m}$

Effect of Box Size on CTF Appearance



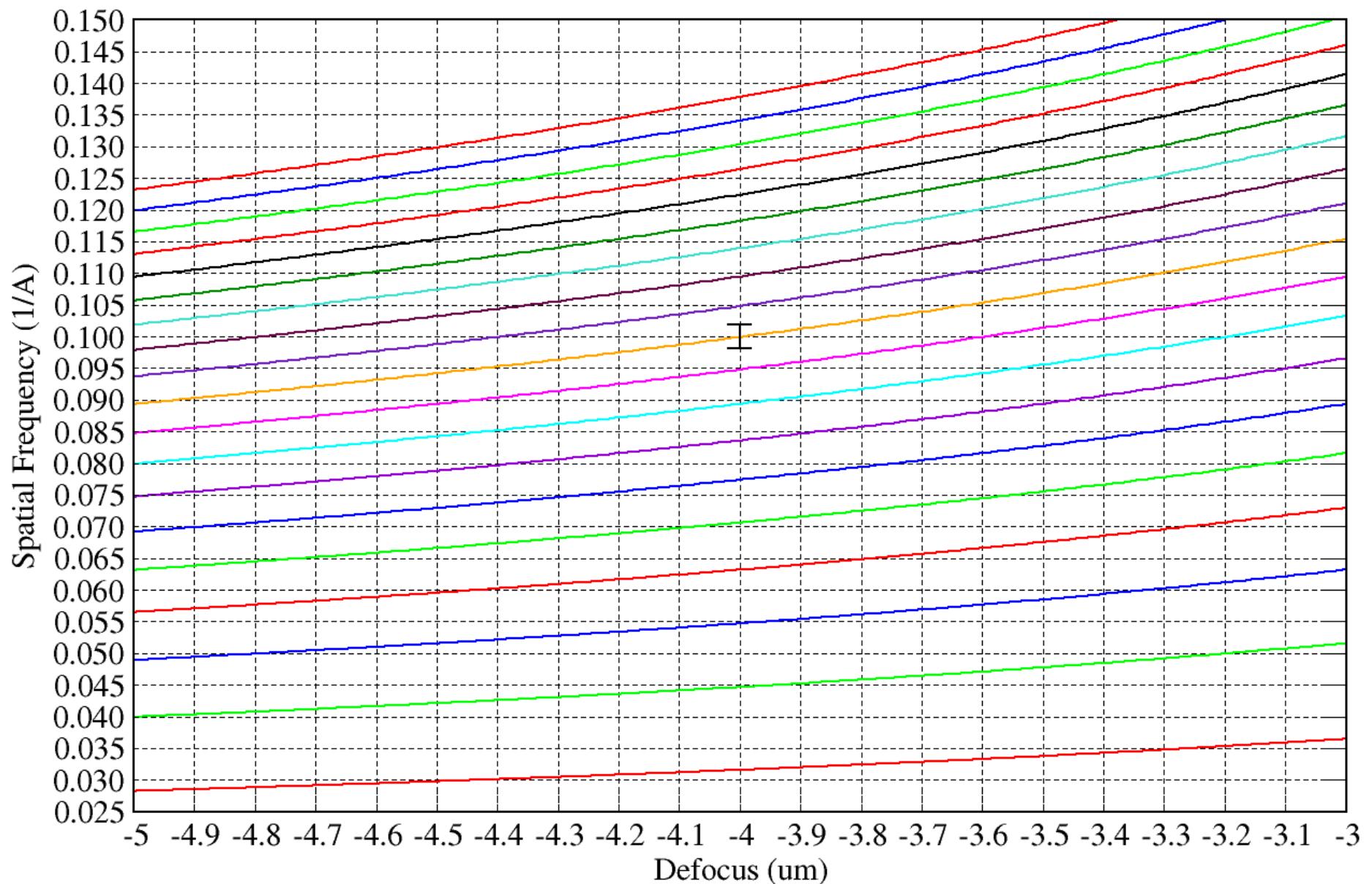
200 kV, $C_s = 1.2\text{mm}$, 2.8\AA/pixel . 192×192 pixels box, $\Delta Z=3 \mu\text{m}$

Effect of Box Size on CTF Appearance



200 kV, $C_s = 1.2\text{mm}$, 2.8 \AA/pixel . 288×288 pixels box, $\Delta Z = 3 \mu\text{m}$

200kV, Cs 1.2mm

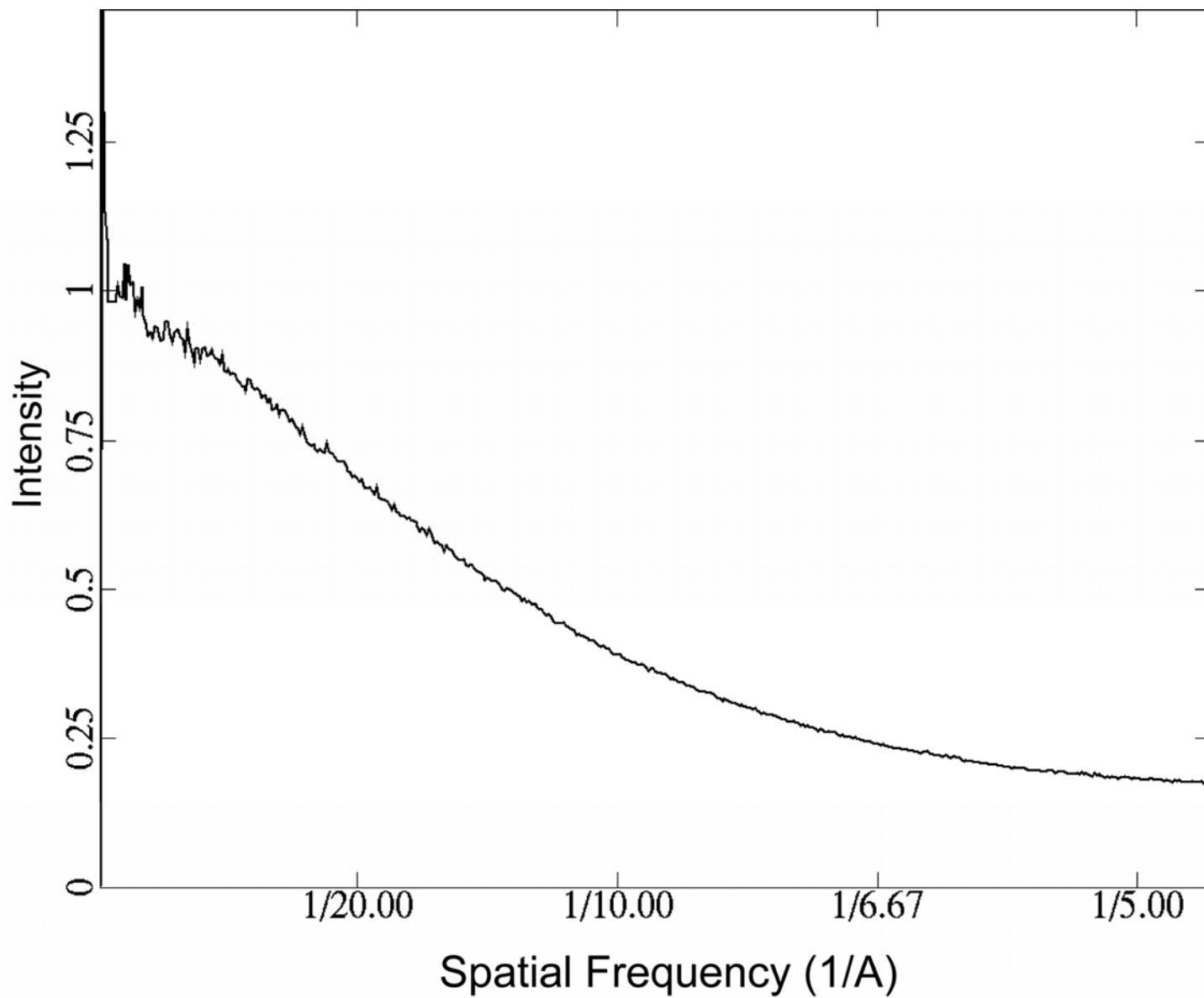


CCD Camera for Single Particle Imaging

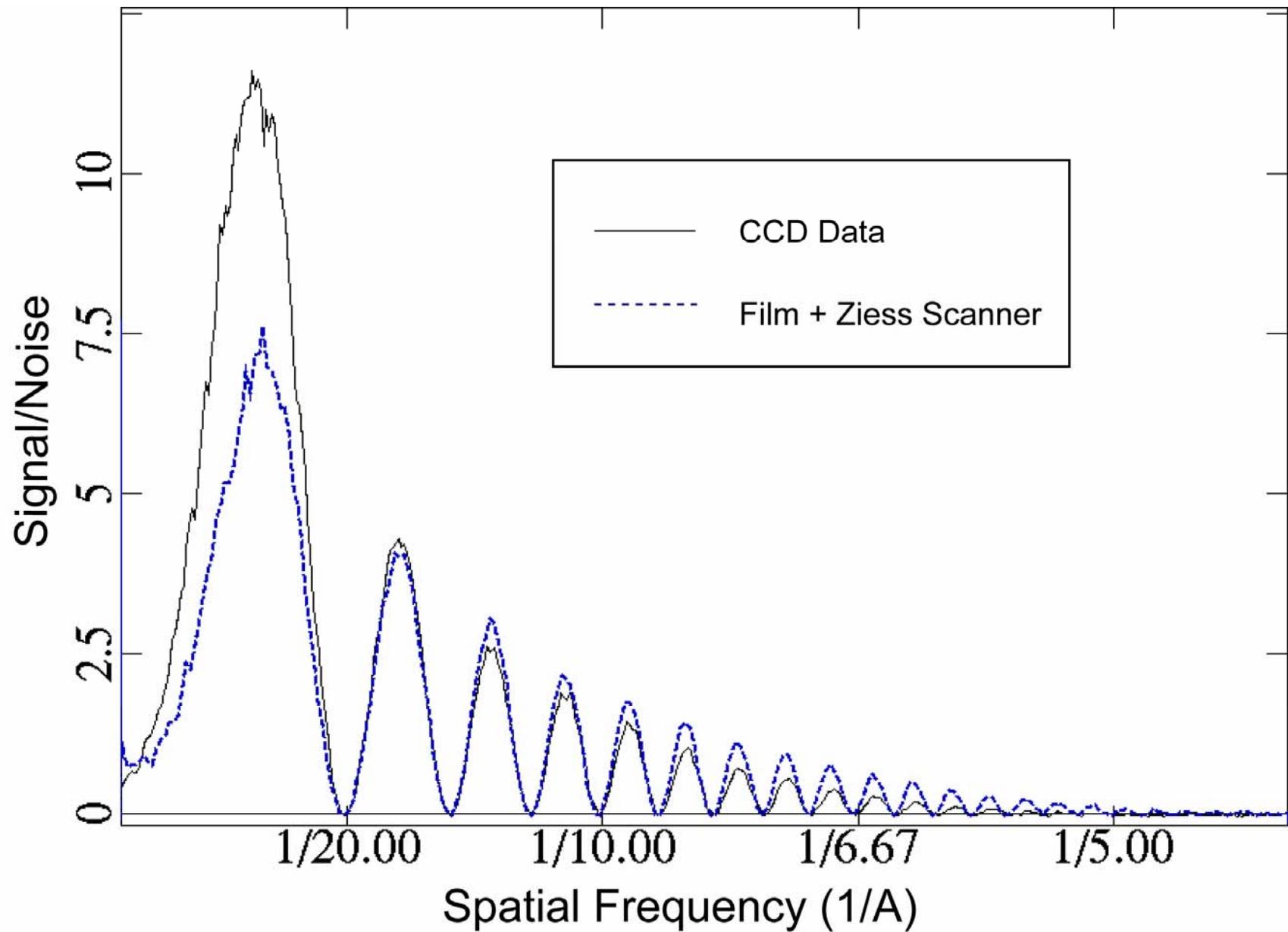
JEM2010F with a Gatan 4k CCD



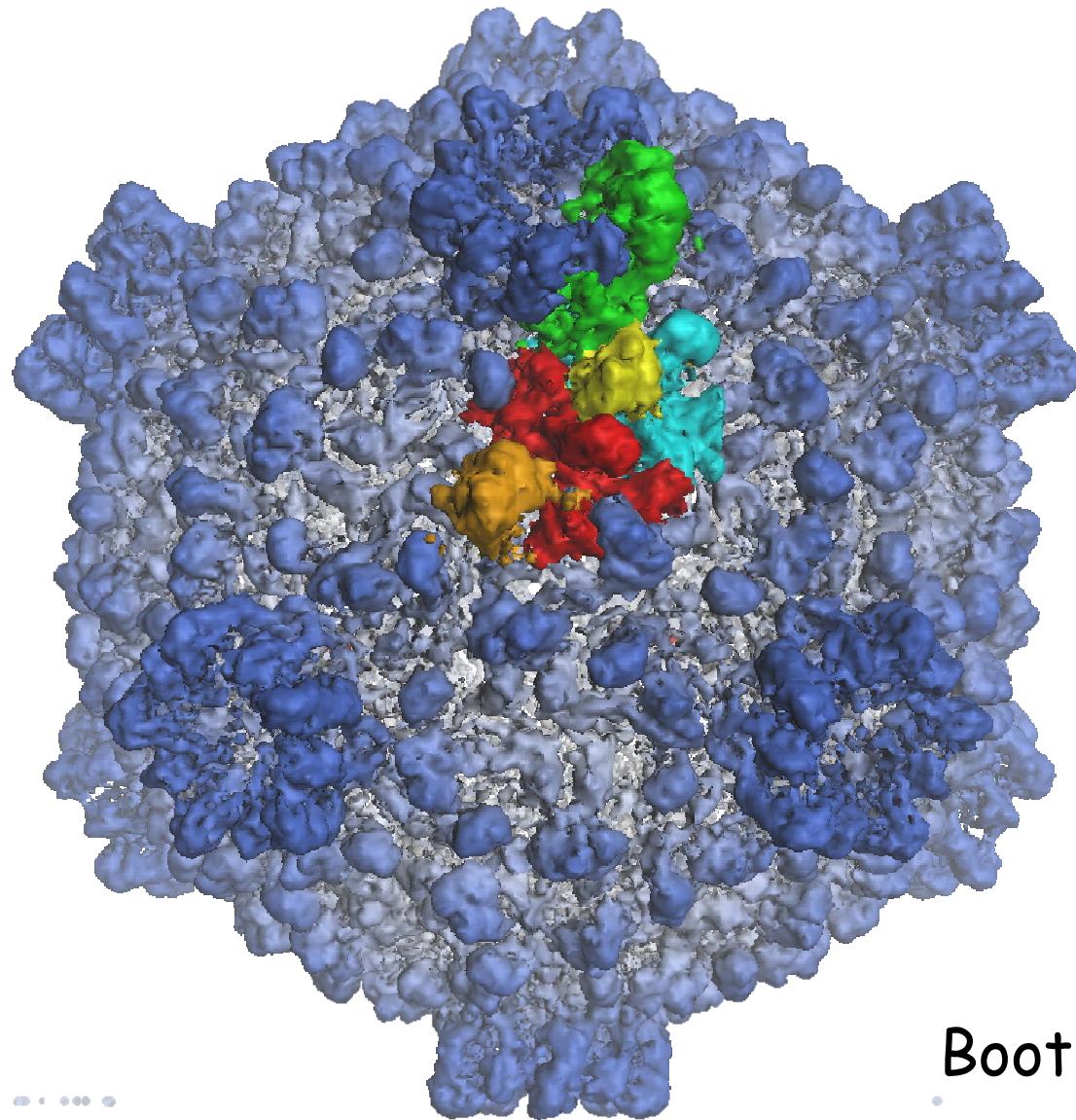
MTF of 4k CCD at 200 kV



S/N of 200 kV Carbon Film Image

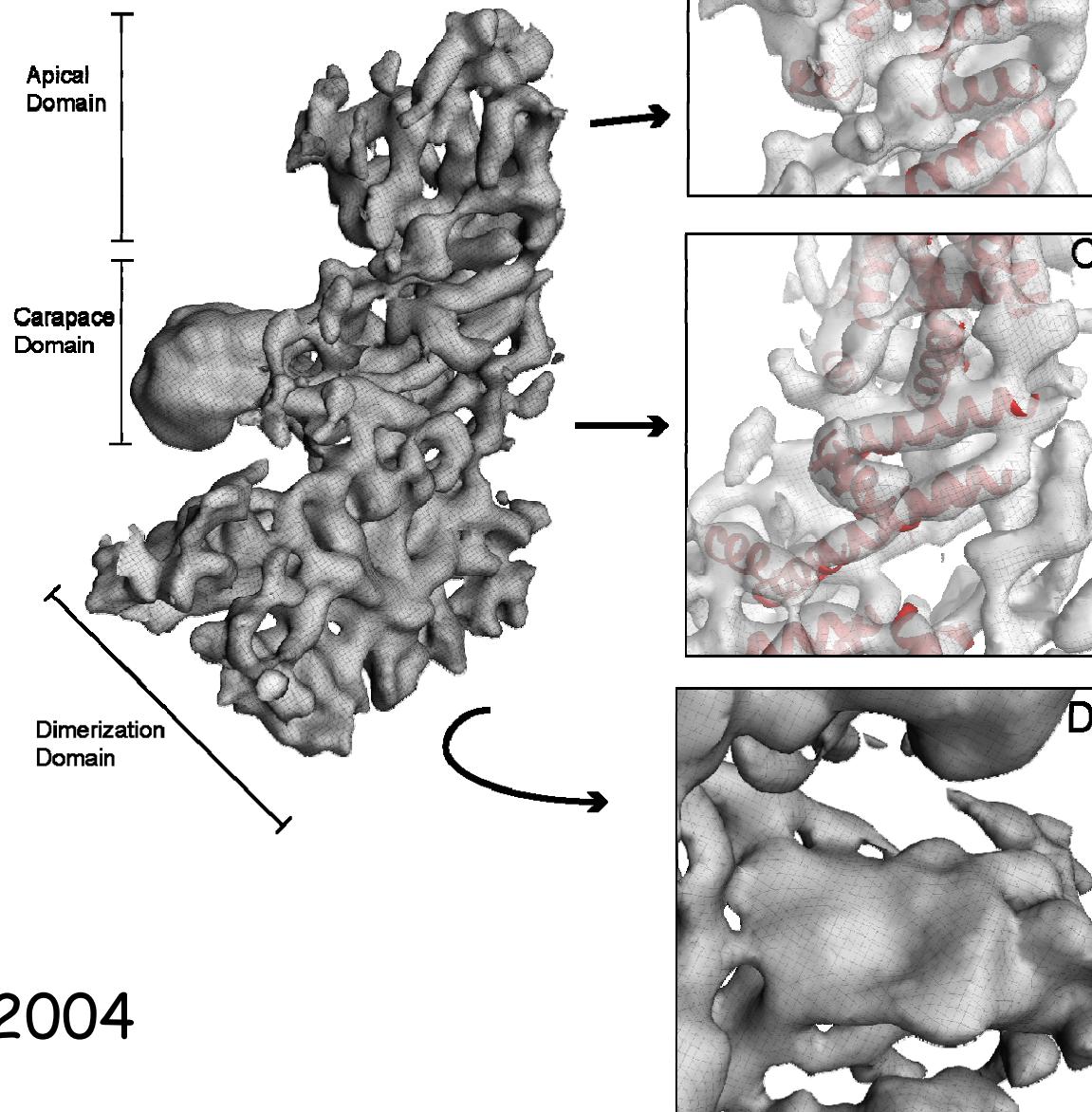


9 Å Map of CPV from CCD Images



Booth et al, JSB 2004

Secondary Structure Elements in CSP-A



Booth, JSB, 2004

Magnification To Use For Higher Resolution Structure Study

Effective Microscope Magnification	Å/pix	Dimension of CCD Frame on Specimen (nm)	% CCD Frame Area wrt 82800 x	2/5 Nyquist (Å)
55,200	2.71	1,110	225	13.55
69,000	2.17	886	144	10.84
82,800	1.81	738	100	9.03
110,400	1.35	554	56	6.77
138,000	1.08	443	36	5.42
207,000	0.72	295	16	3.61

15 microns/pixel Gatan 4k CCD

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